

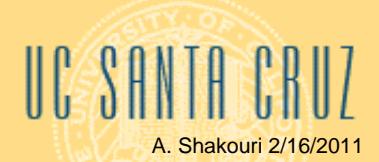
# Ultrafast Nanoscale Electrothermal Energy Conversion Devices and Measurements

Ali Shakouri  
Baskin School of Engineering  
University of California Santa Cruz

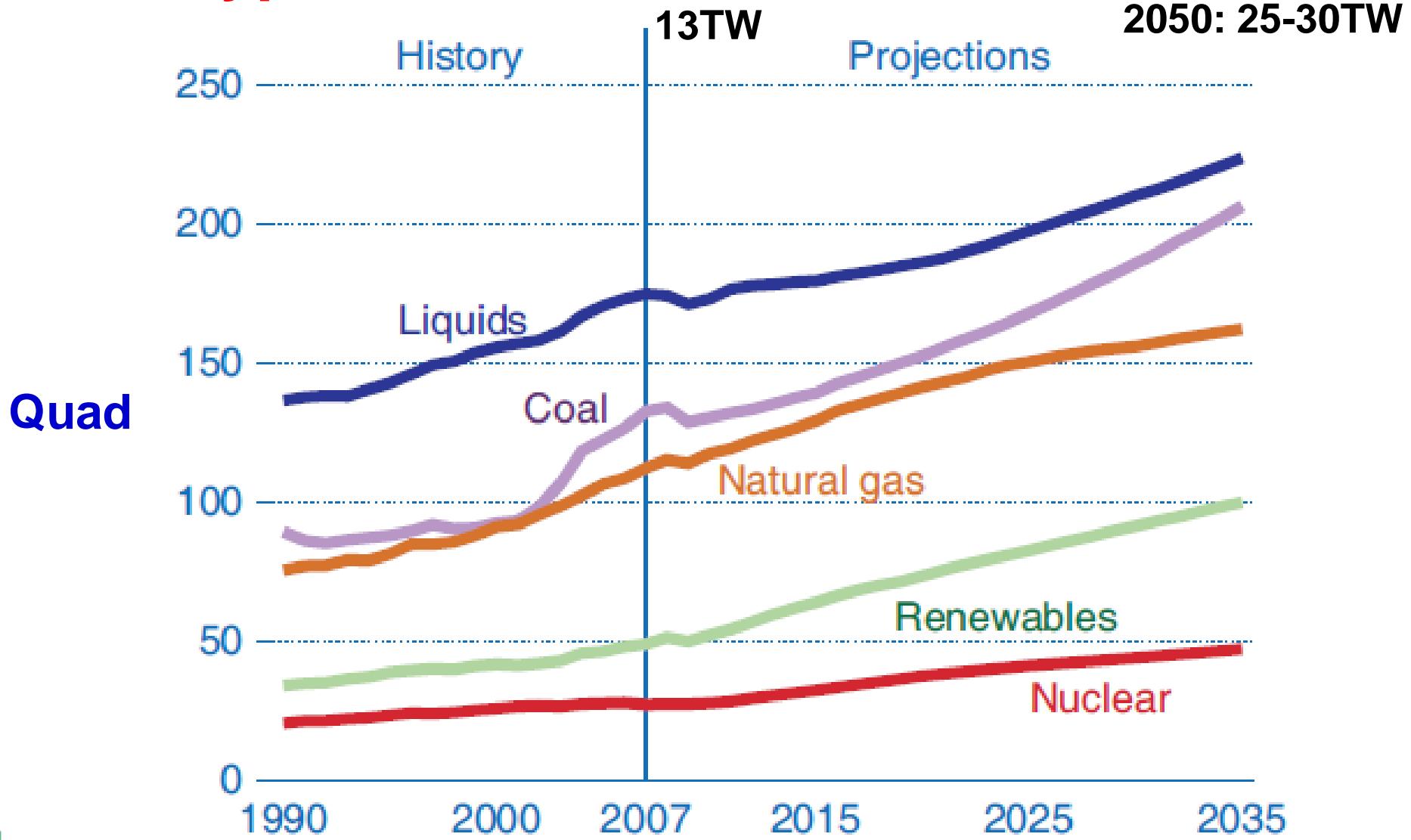


Acknowledgement: ONR,  
DARPA, AFOSR, CEA, NSF,  
DOE/EFRC, NASA/UCSC  
National Semiconductor,  
Intel, Canon, Wyle Lab, SRC-IFC

# World Marketed Energy Use by Fuel Type 1990-2035



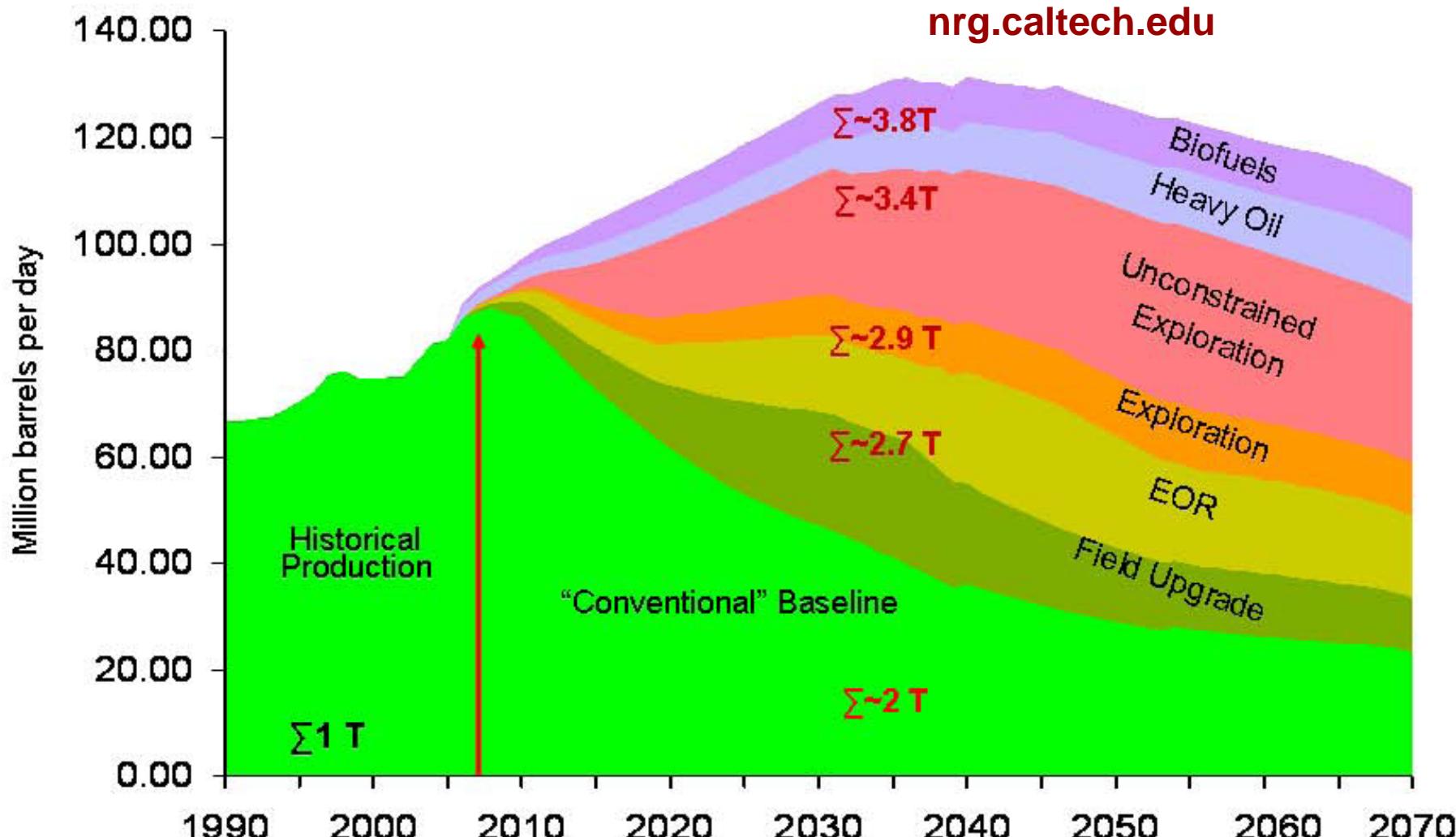
A. Shakouri 2/16/2011



# A Future: ~ 3.5 Trillion bbls Oil Resources



S. Koonin, Former Chief Scientist BP  
nrg.caltech.edu

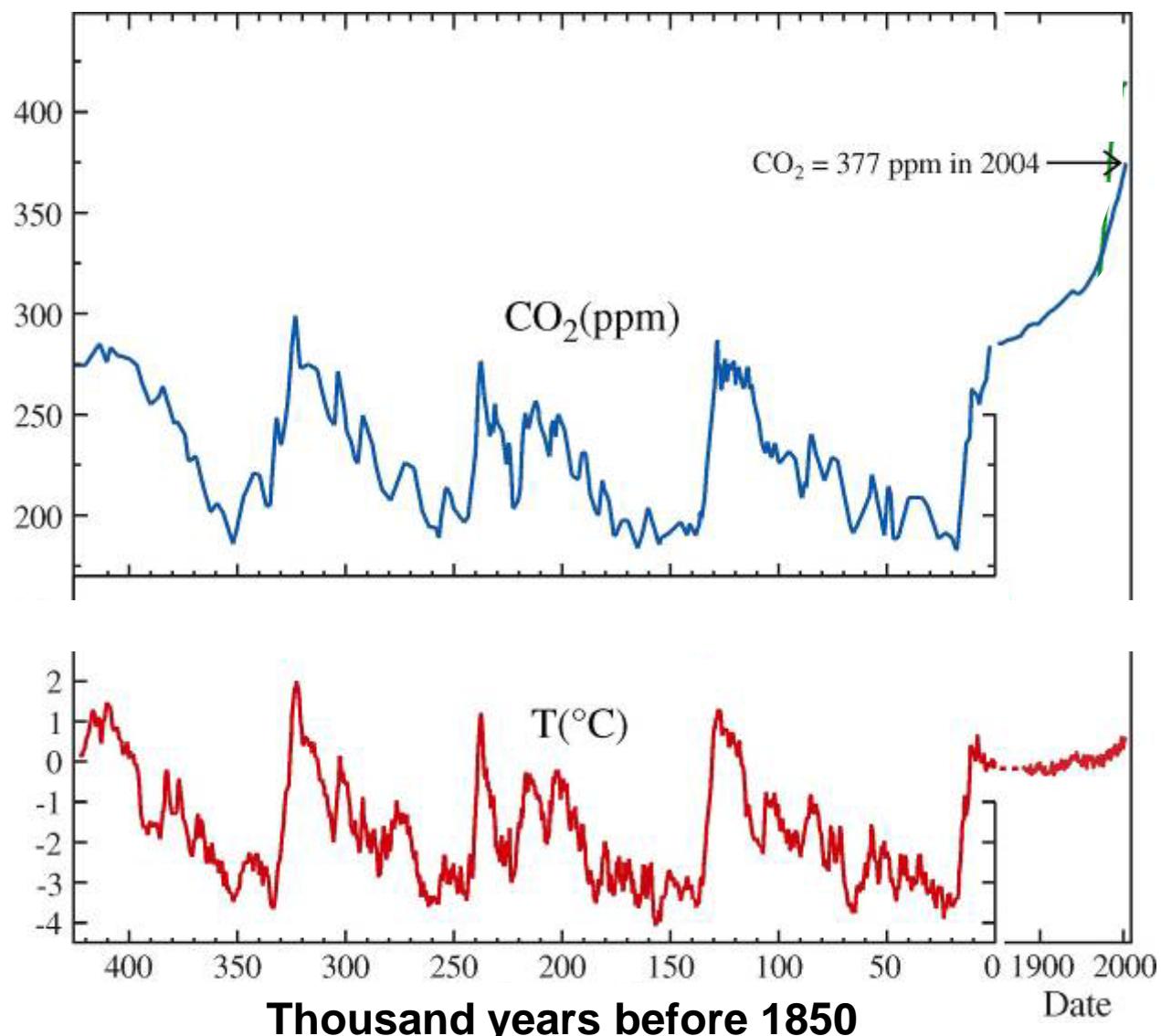


Source: Modified from Cambridge Energy Research Associates, Inc. (CERA). The use of this graphic was authorized in advance by CERA. No other use, or redistribution of this information is permitted without written permission by CERA."

# 400,000 years of greenhouse-gas & temperature history based on bubbles trapped in Antarctic ice

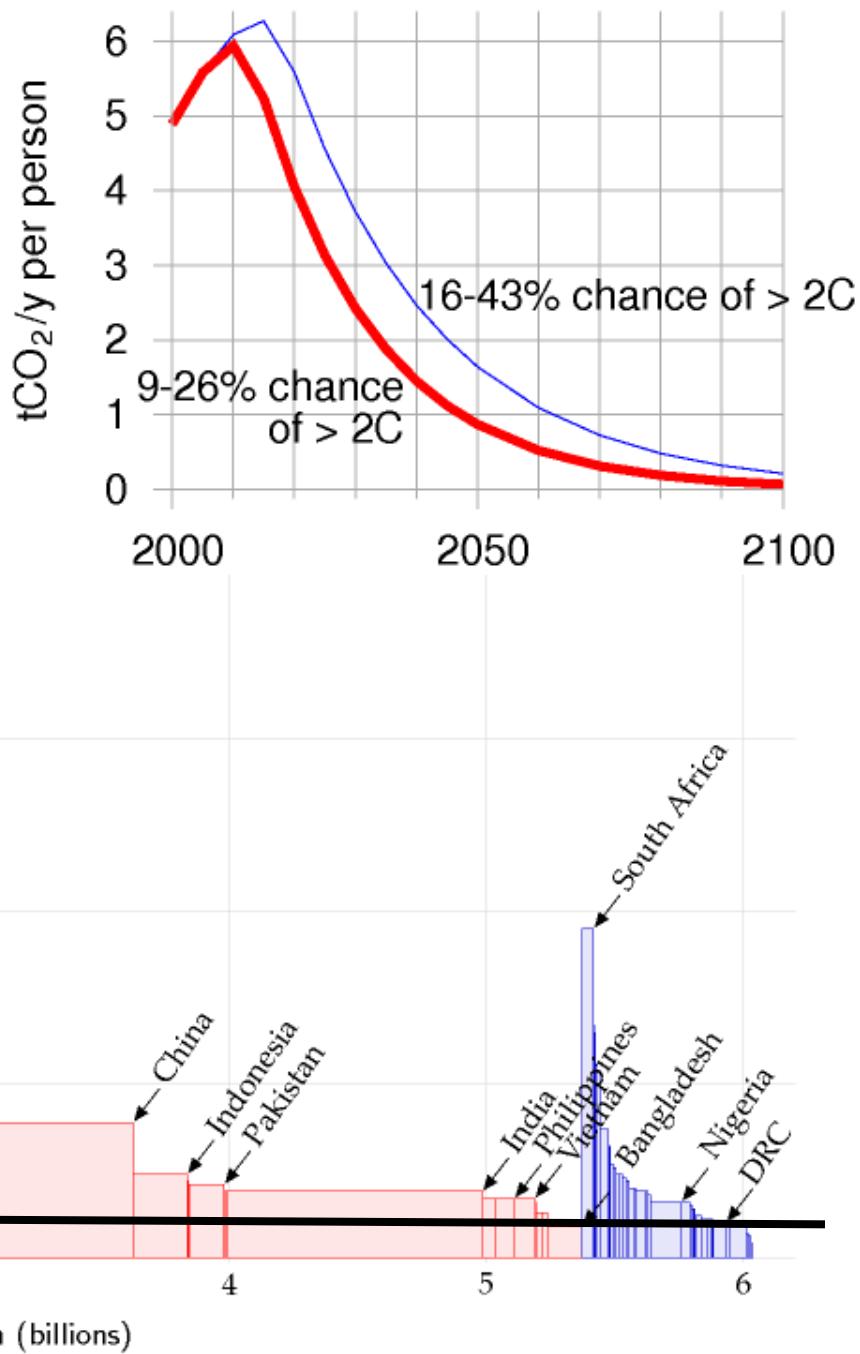
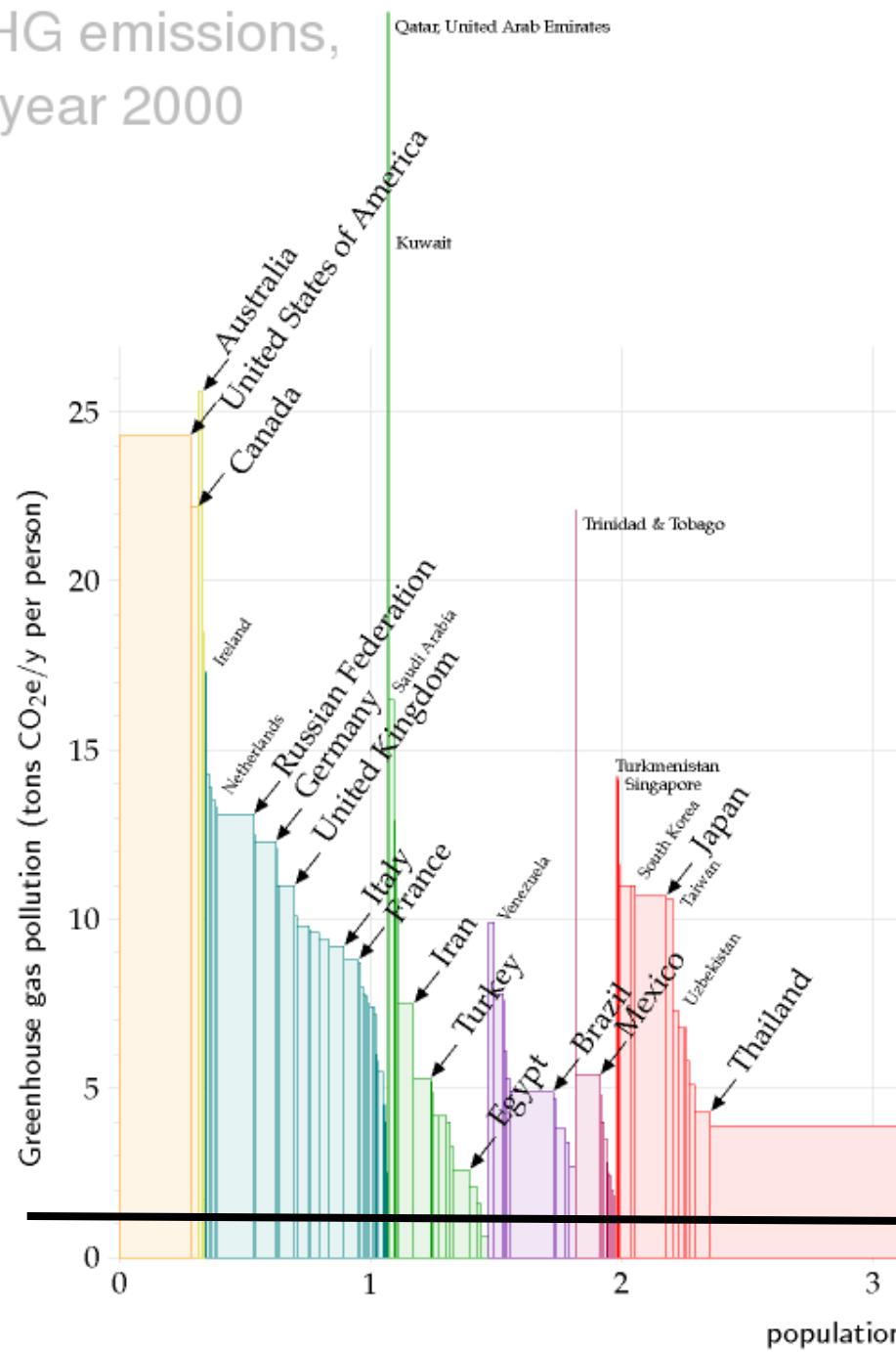
Last time CO<sub>2</sub> >300 ppm was 25 million years ago.

Source: Hansen,  
*Clim. Change*, **68**,  
 269, 2005.



*John P. Holdren, 2006*

# GHG emissions, year 2000

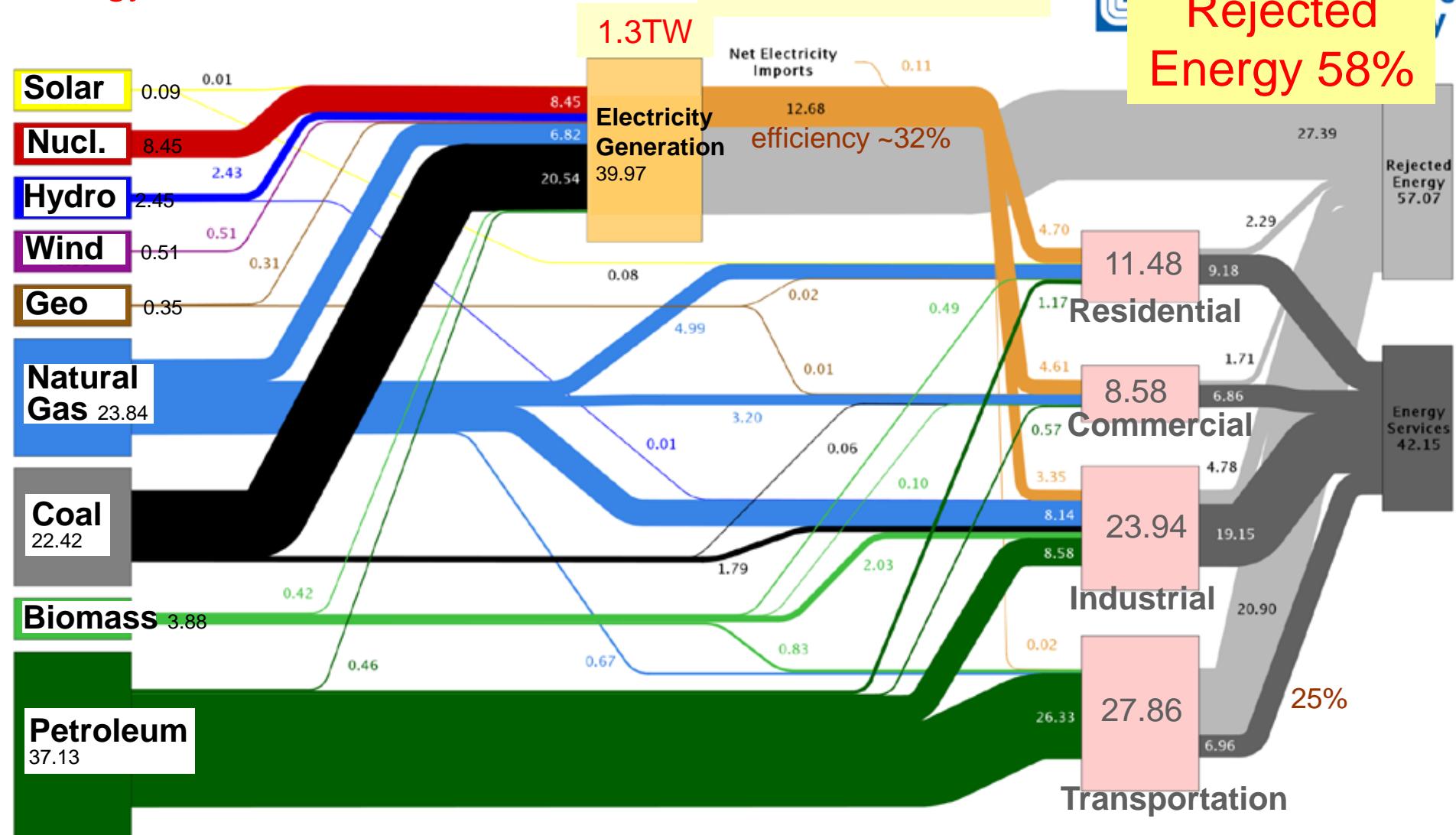


Data source: Climate Analysis Indicators Tool (CAIT) Version 4.0. (Washington, DC: World Resources Institute, 2007).

# US Energy Flow 2008

Energy Use = 99.2 Quad = 105 EJ → Power ~3.3 TW

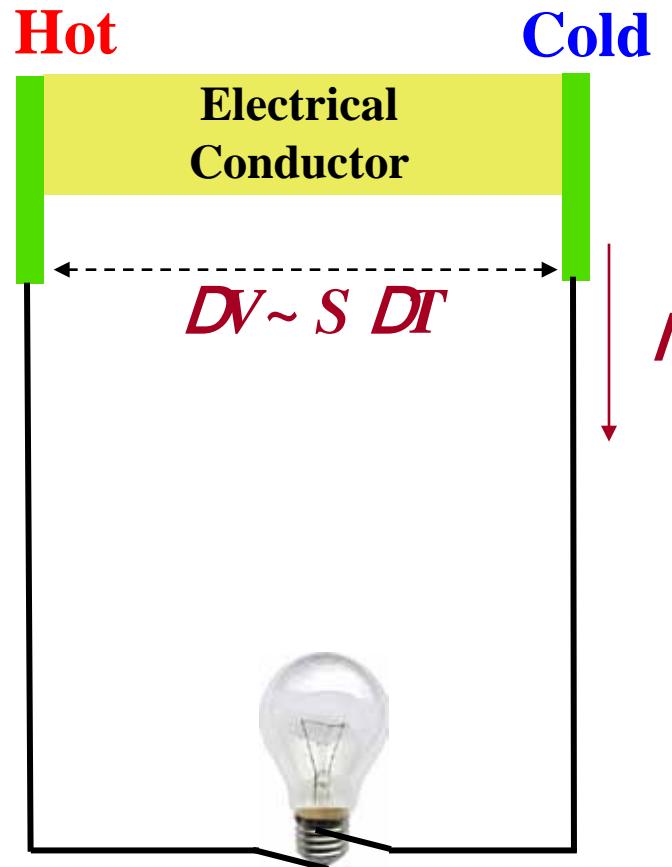
Rejected Energy 58%



Quads

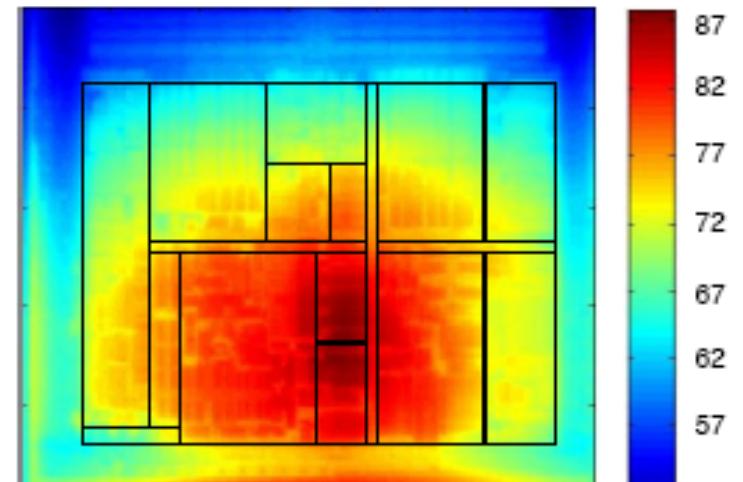
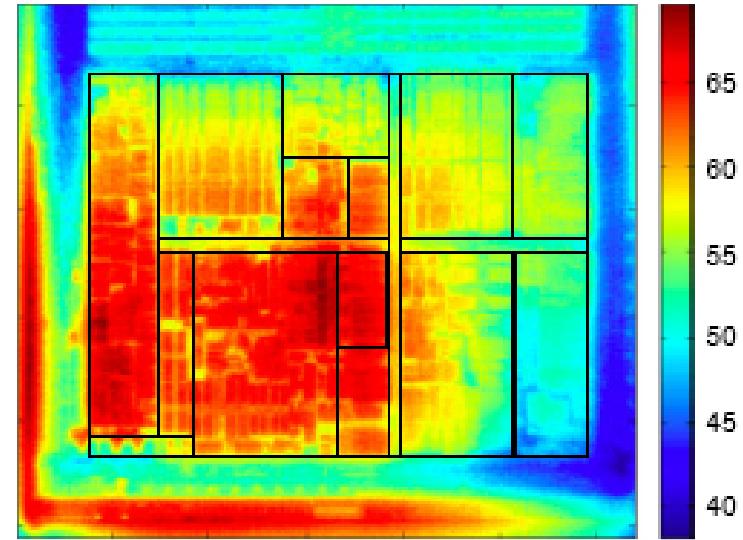
# Direct Conversion of Heat into Electricity

Seebeck  
(1821)



# Impact of 15°C temperature increase on IC performance

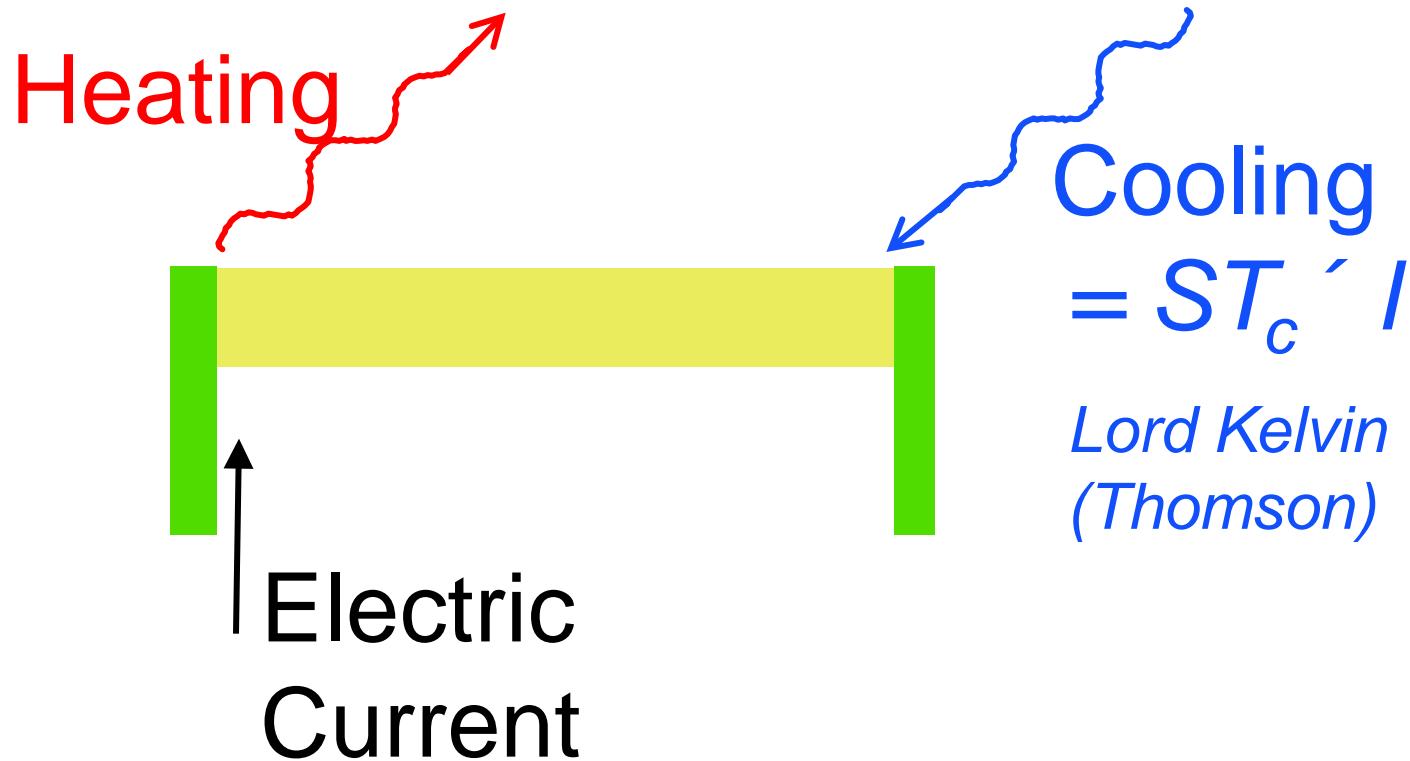
- Leakage power exponential increase with temperature
  - 60nm → 50-70% of total power
  - Potential thermal runaway
- Lifetime exponential decrease with temperature ( $\times \frac{1}{4}$ ) – e.g. electromigration, oxide breakdown
- Interconnect delay (10-15%)
- Crosstalk noise ( $\uparrow$  up to 25%)



Thermal integrity: a must for low-power-IC digital design, EDN 15 Sept. 2005

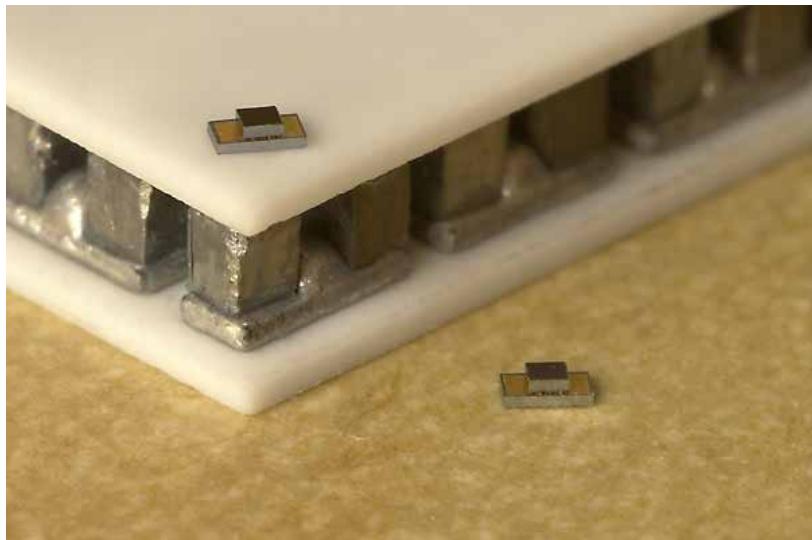
<http://masc.cse.ucsc.edu>

# Peltier Effect (1834)

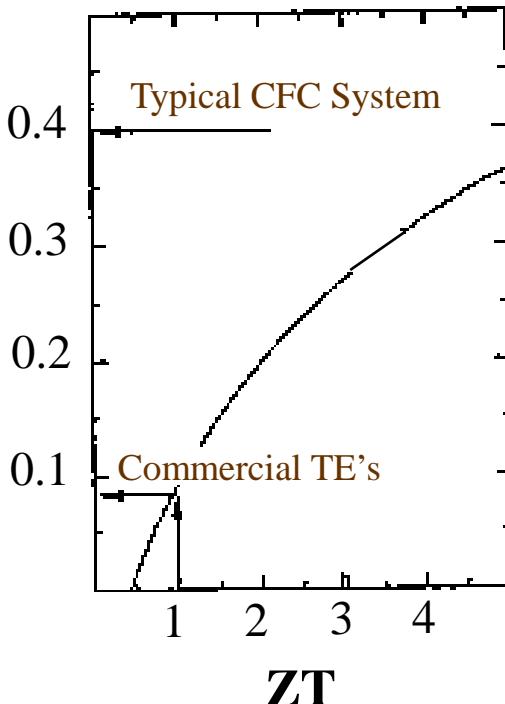


Reverse of Seebeck effect (electric current produces cooling/heating)

# Thermoelectric (Peltier) Coolers



Fraction of  
Carnot  
Efficiency



$$Z = \frac{S^2 s}{k}$$

$$Z = \frac{(Seebeck)^2 (electrical\ conductivity)}{(thermal\ conductivity)}$$

Conventional  
thermoelectrics have  
**low efficiencies** and  
**low cooling power**  
**density <50-100W/cm<sup>2</sup>.**

# TEs for Telecom Cooling

- Melcor, Marlow and many other TE manufacturers provide coolers specifically designed for Telecom laser-cooling applications



Typical Distributed Feedback Laser:

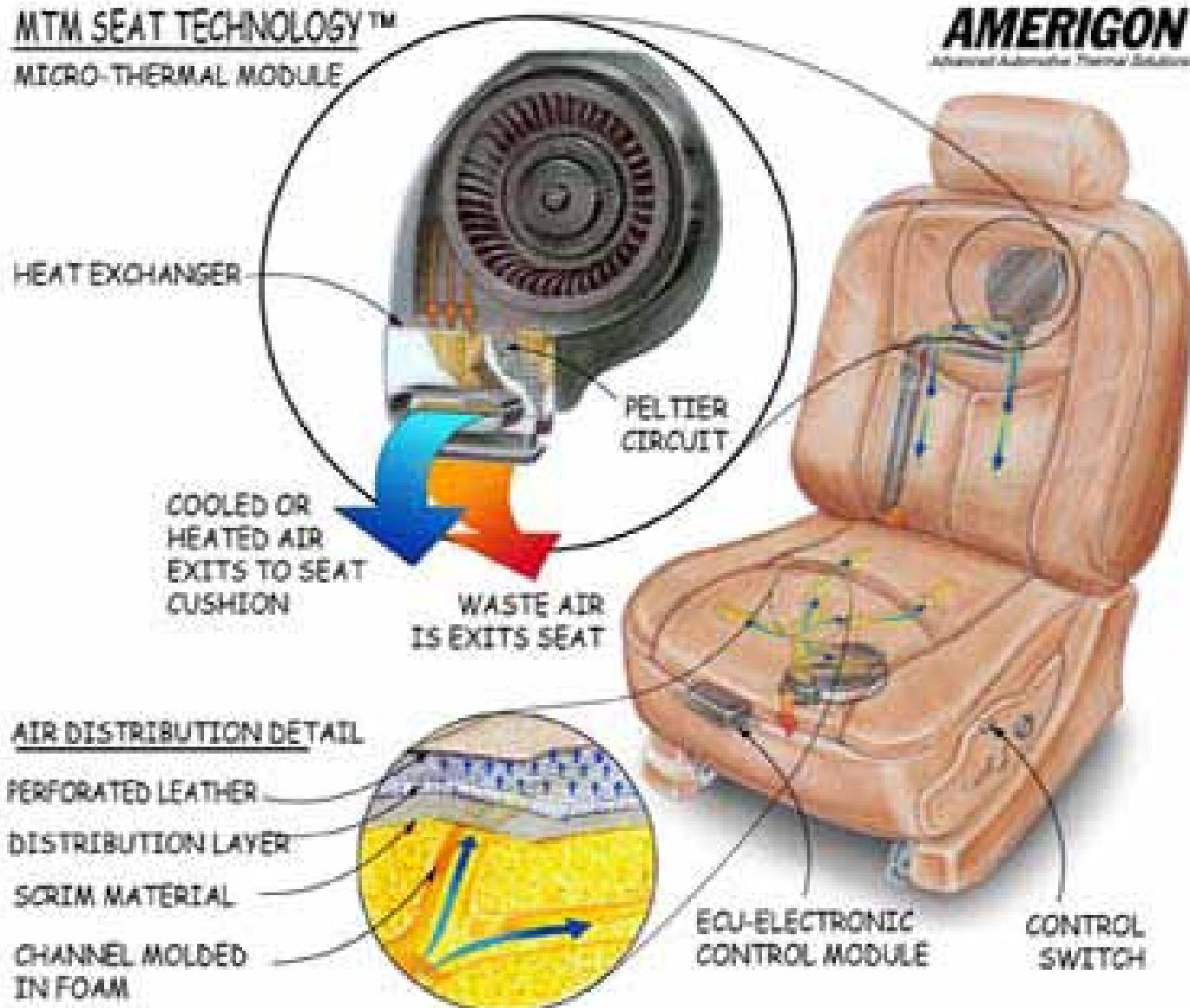
$$\frac{DI}{DT} = 0.1 \text{ nm}/^\circ\text{C}$$

Heat generation kW/cm<sup>2</sup>



Cronin Vining, ZT Services

# Thermoelectrically-Cooled/Heated Car Seat

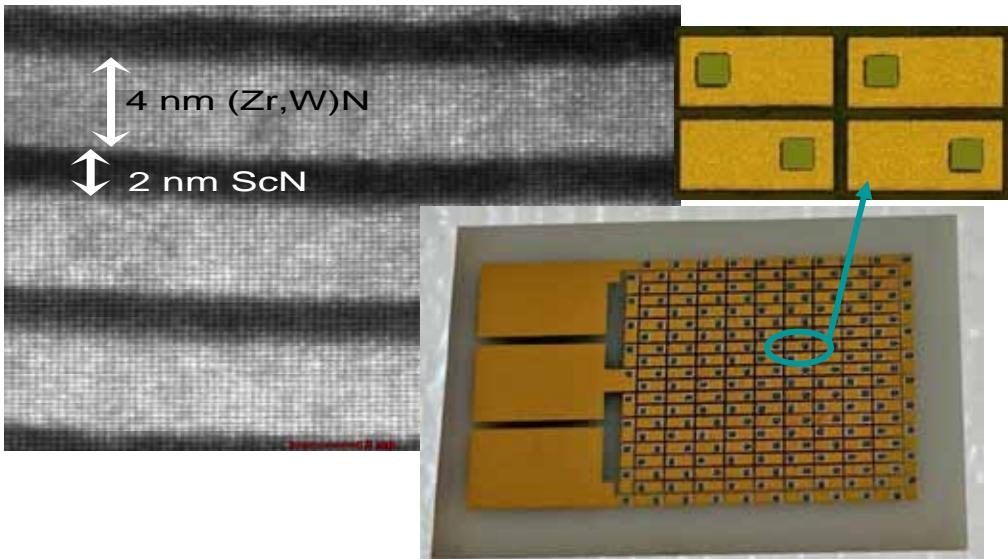


Lon Bell  
BSST

# Solid-State Thermoelectric Energy Conversion using Nanostructured Materials

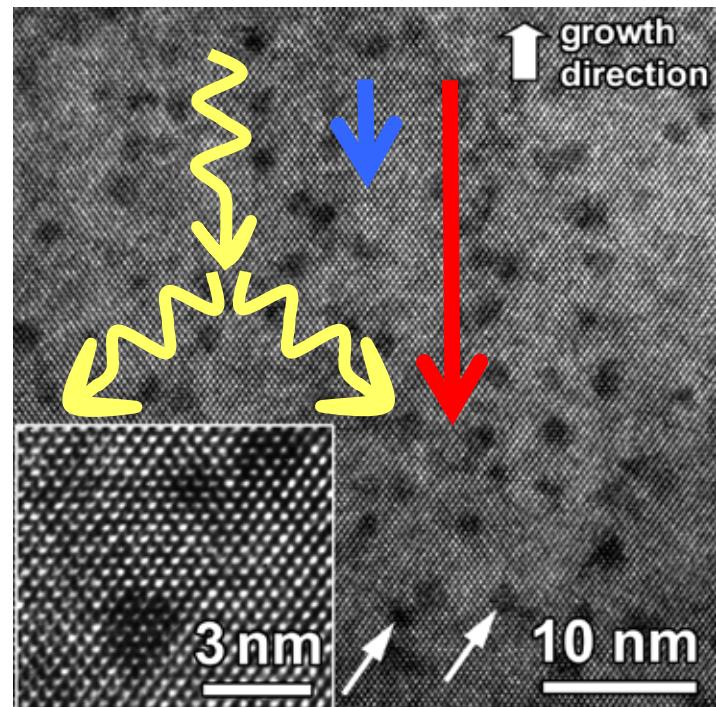
# Thermionic Energy Conversion Center

Ali Shakouri, Director



**Engineering current and heat flow using nanostructures**

**Goal: direct conversion of heat into electricity with > 20-30% efficiency**



**UCSC (Bian, Kobayashi),  
Berkeley (Majumdar), BSST  
Inc. (Bell), Delaware (Zide),  
MIT (Ram), Purdue (Sands),  
UCSB (Bowers, Gossard)**

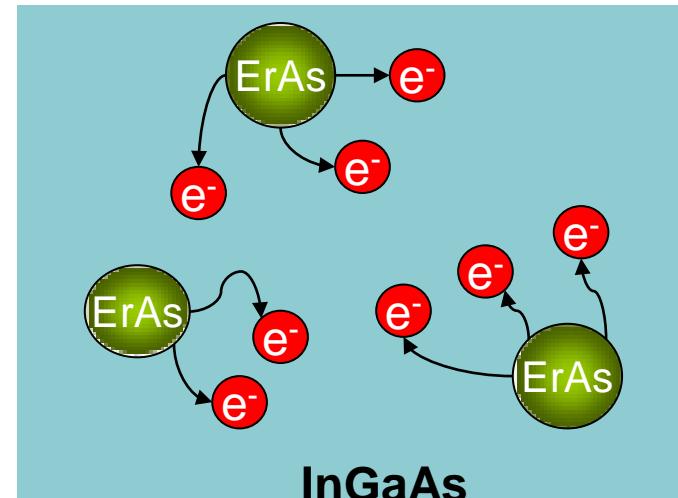
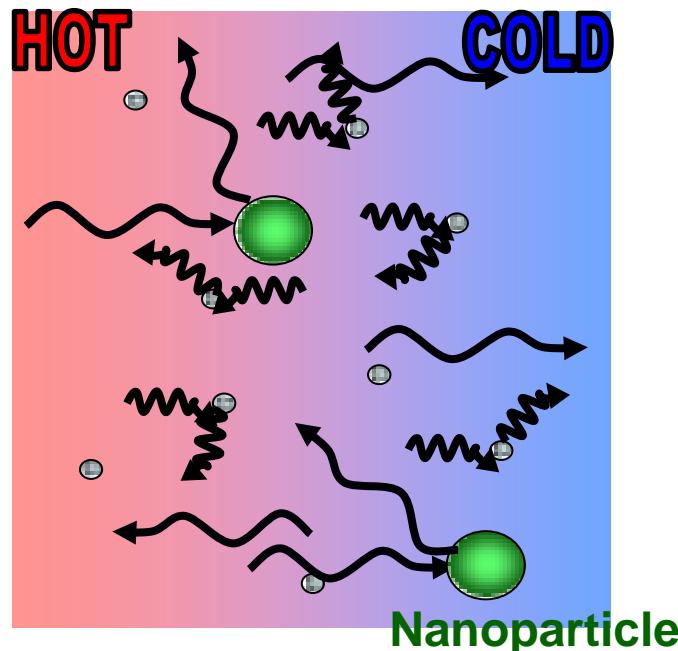
Funding: DARPA, ONR, DOE, NSF

# Two beneficial effects of metal nanoparticles on thermoelectric performance

Metal nanoparticles **scatter phonons**  
Δ reduced thermal conductivity

Metal nanoparticles **donate electrons**  
Δ enhanced electrical conductivity by increasing electron density in the semiconductor matrix

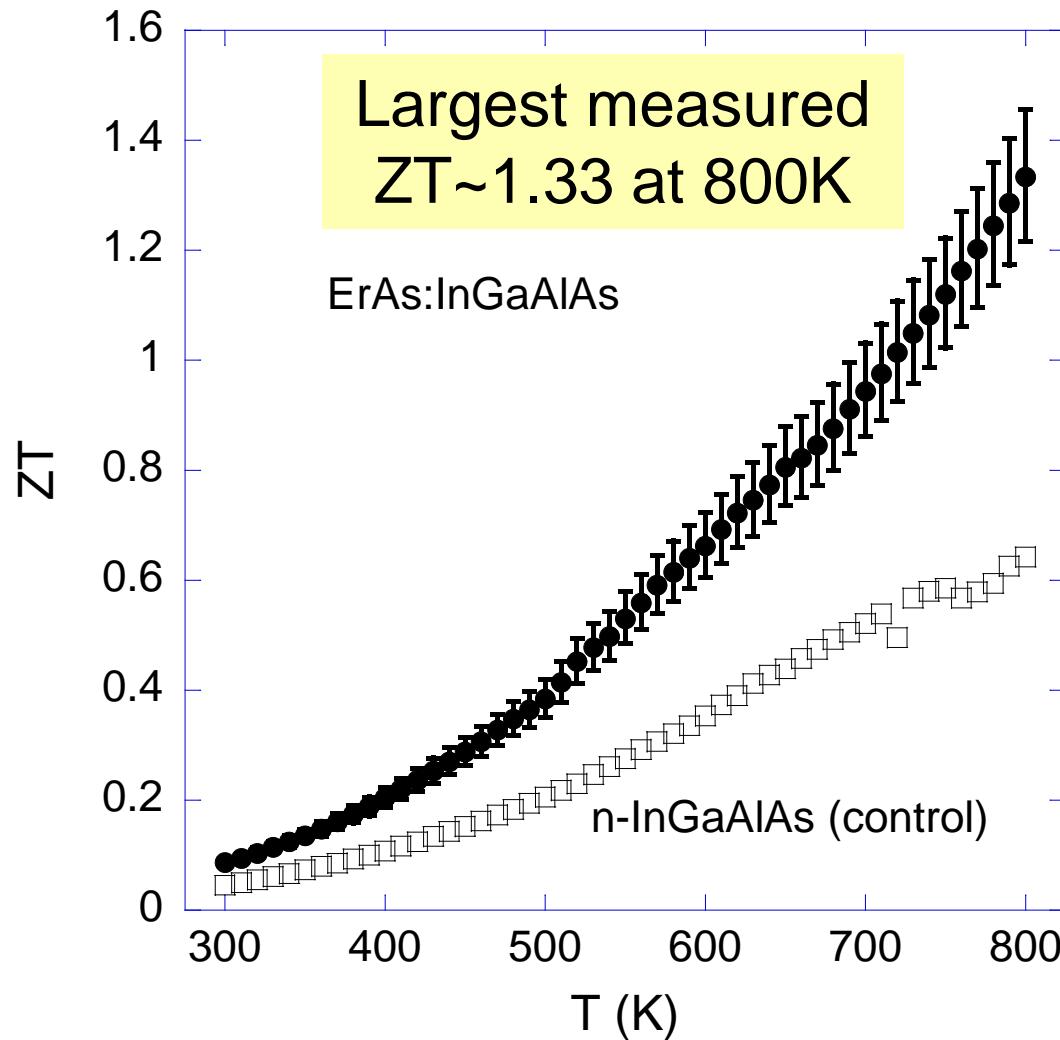
$$Z = \frac{(\text{Seebeck})^2 (\text{electrical conductivity})}{(\text{thermal conductivity})}$$



D. Vashaee and A. Shakouri, *Phys. Rev. Lett.* 92, 106103/1 (2004)

C. Vineis et al. Nano. Thermoelectrics: big efficiency gains from small features, *Advanced Materials* (2010) <sub>15</sub>

# Thermoelectric figure-of-merit

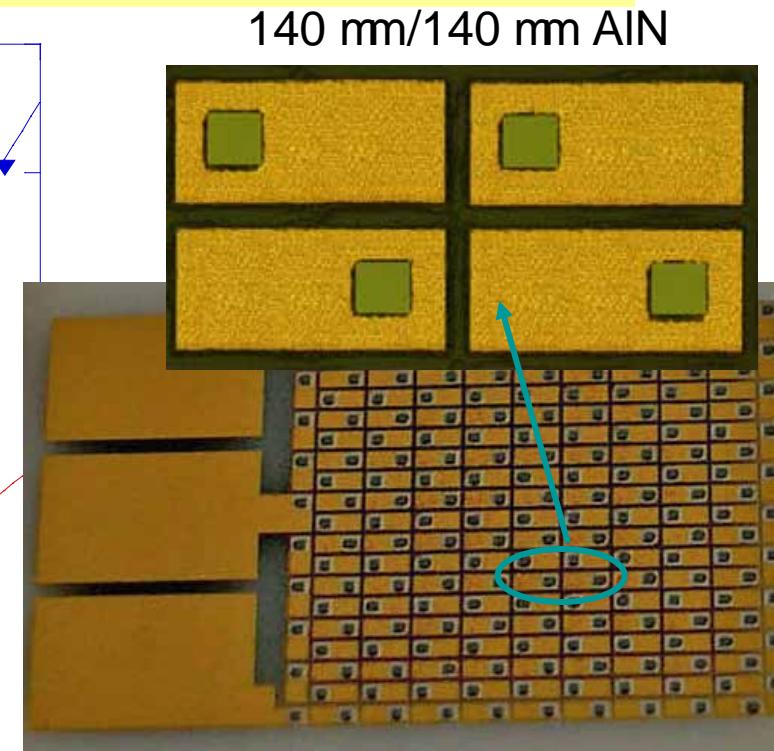
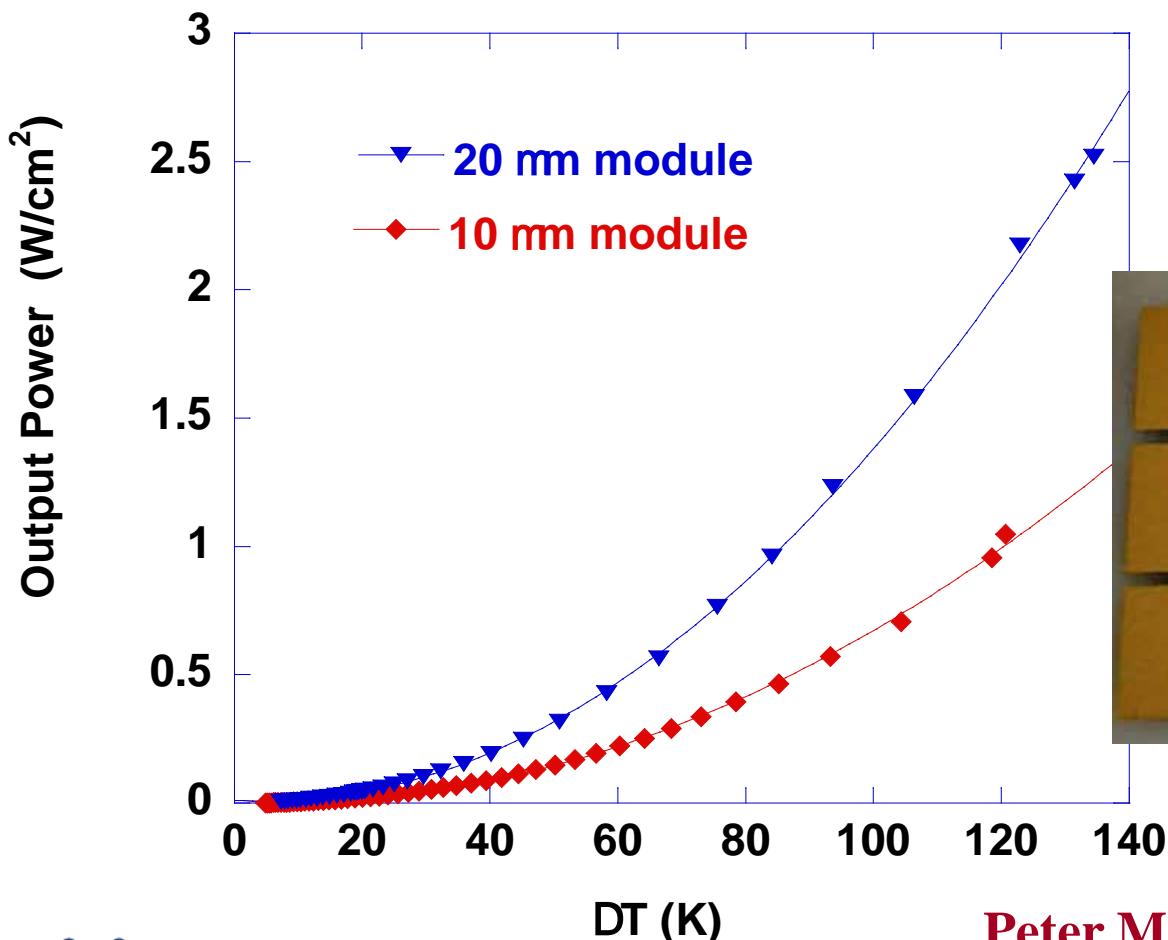


J. Zide et al. Journal of Applied Physics (Dec. 2010)

The majority of ZT enhancement is from thermal conductivity reduction.  
5% power factor enhancement at 800K.

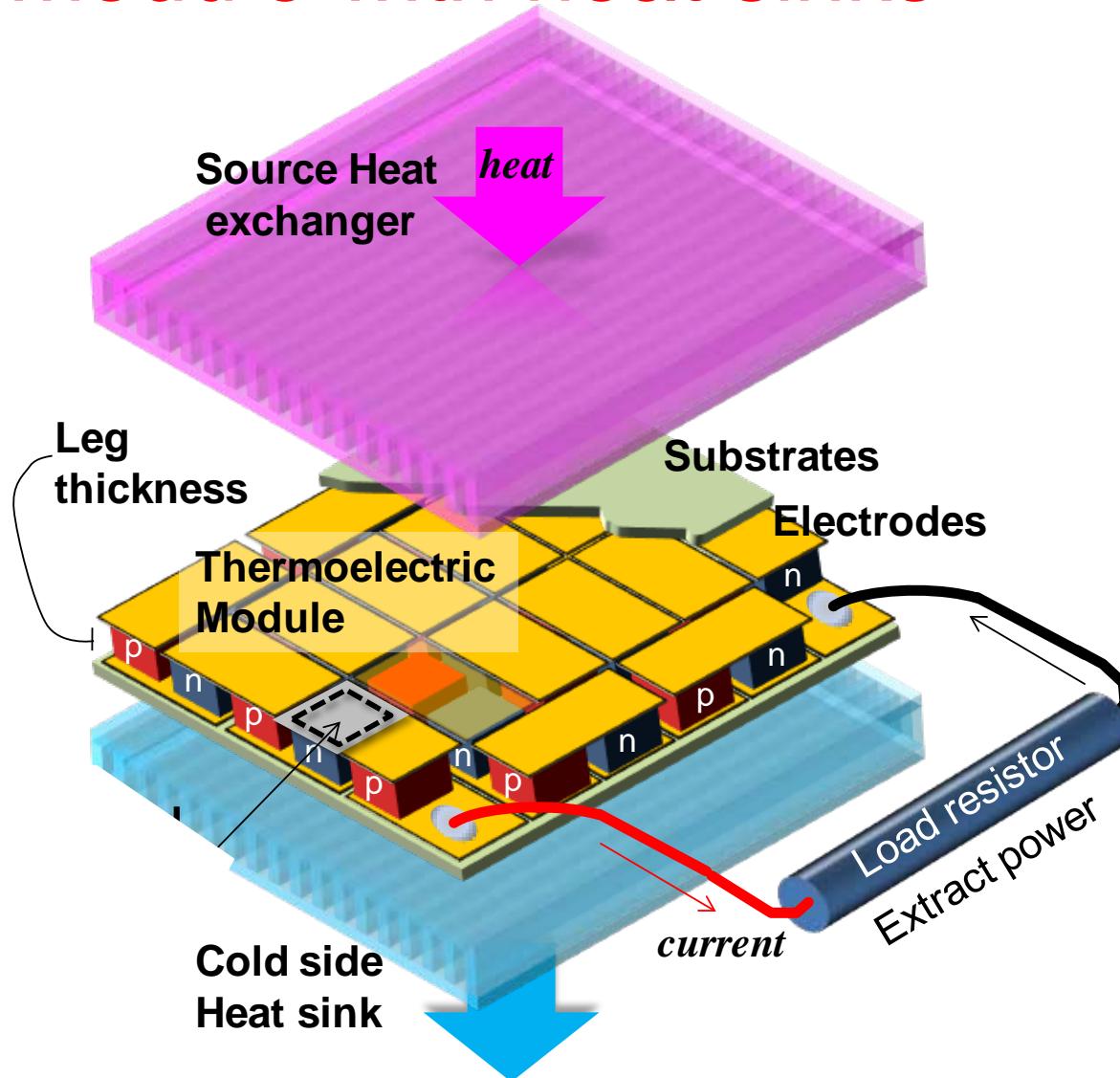
# Module power generation results

400 elements (10-20 microns ErAs:InGaAlAs thin films,  
120x120mm<sup>2</sup>), array size 6x6 mm<sup>2</sup>

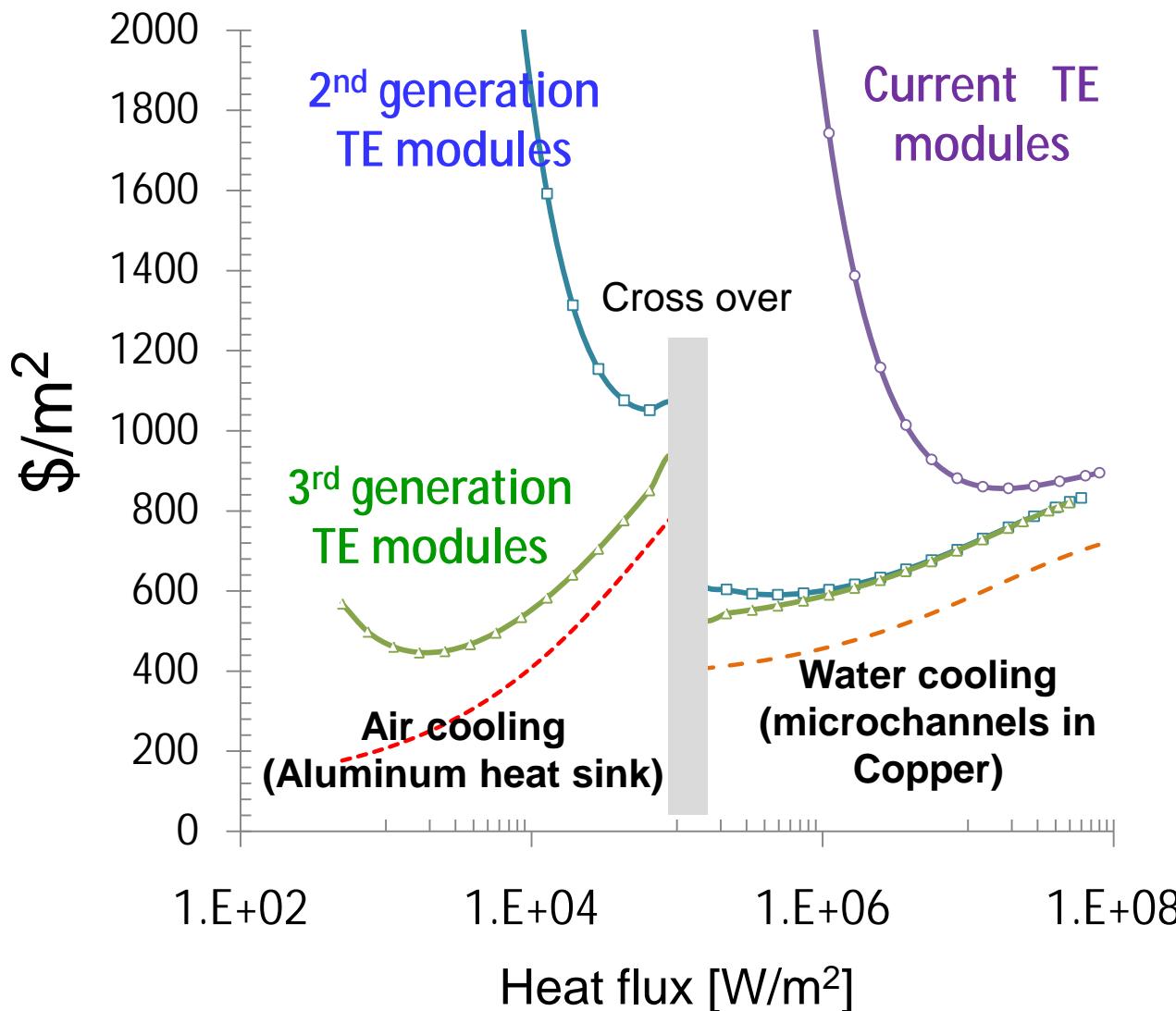


Peter Mayer and Rajeev Ram MIT  
TE module requirements

# Co-optimization of thermo-electric module with heat sinks



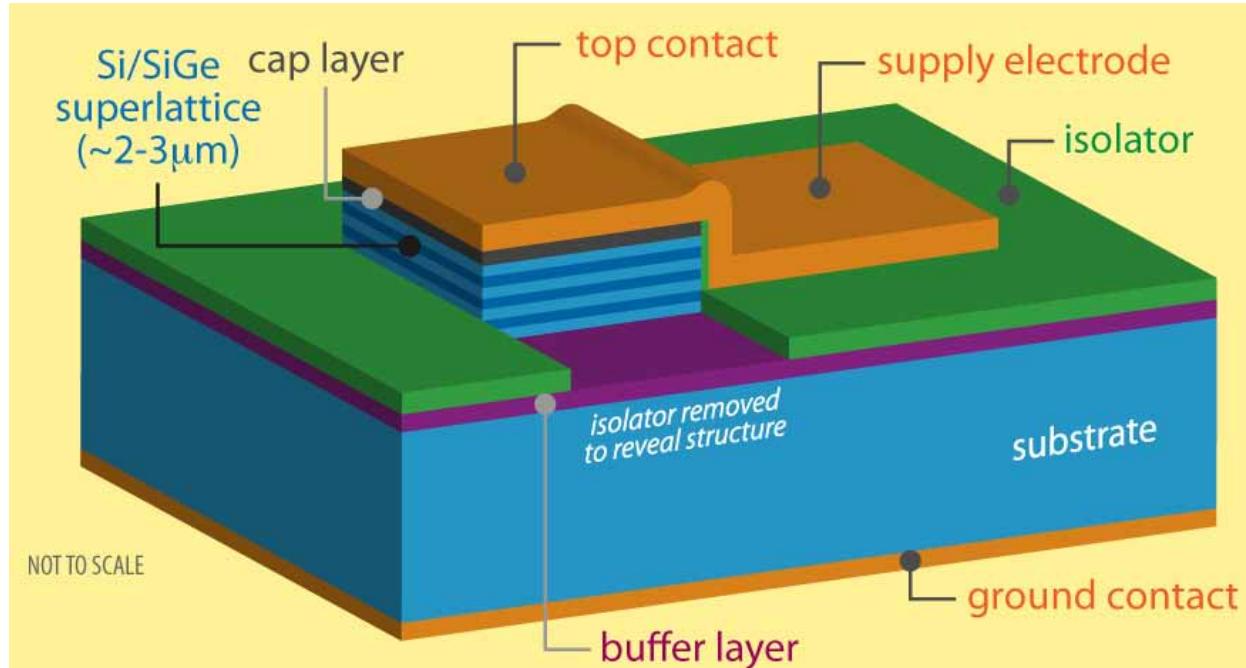
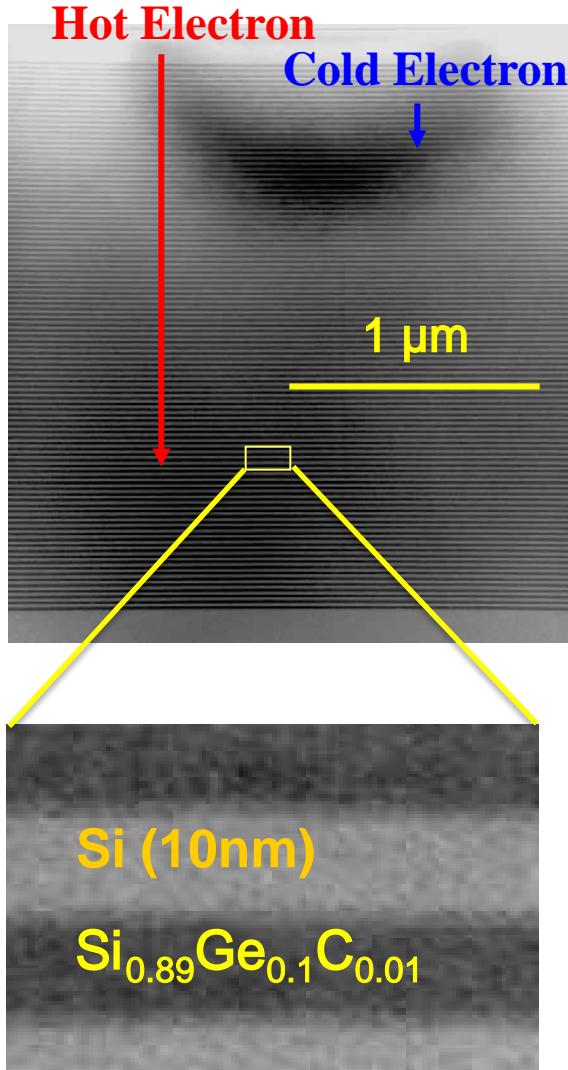
# Material cost of TE power generation system



Today's TE power generation cost:  
\$1-2/W

Potential to bring this down to:  
\$0.1/W

# Microrefrigerators on a chip

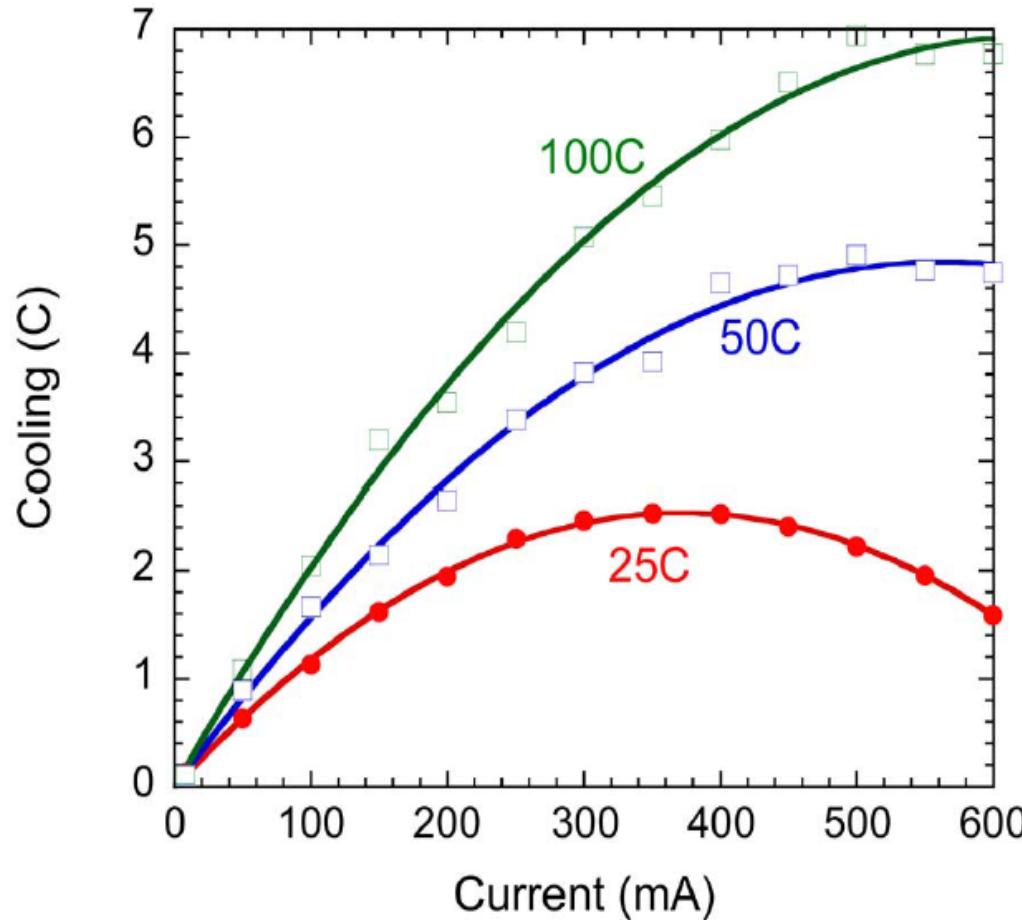


Heterostructure Integrated Thermionic Coolers; A. Shakouri and John Bowers, *Appl. Phys. Lett.* 1997

Nanoscale heat transport and microrefrigerators on a chip; A. Shakouri, *Proceedings of IEEE*, July 2006

# Microrefrigerators on a chip

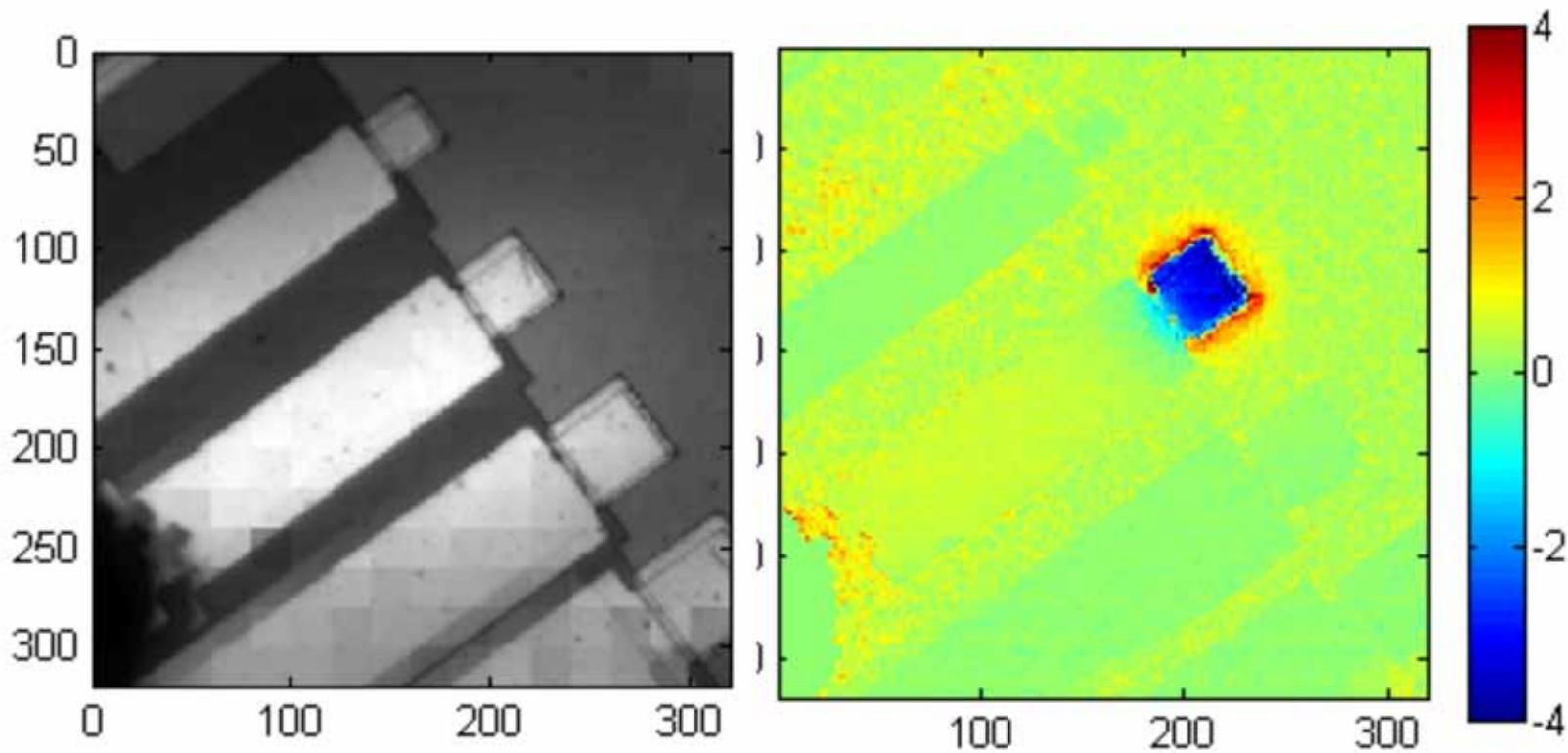
- Monolithic integration on silicon
- $\Delta T_{\max} \sim 4\text{C}$  at room temp. ( $7\text{C}$  at  $100\text{C}$ )



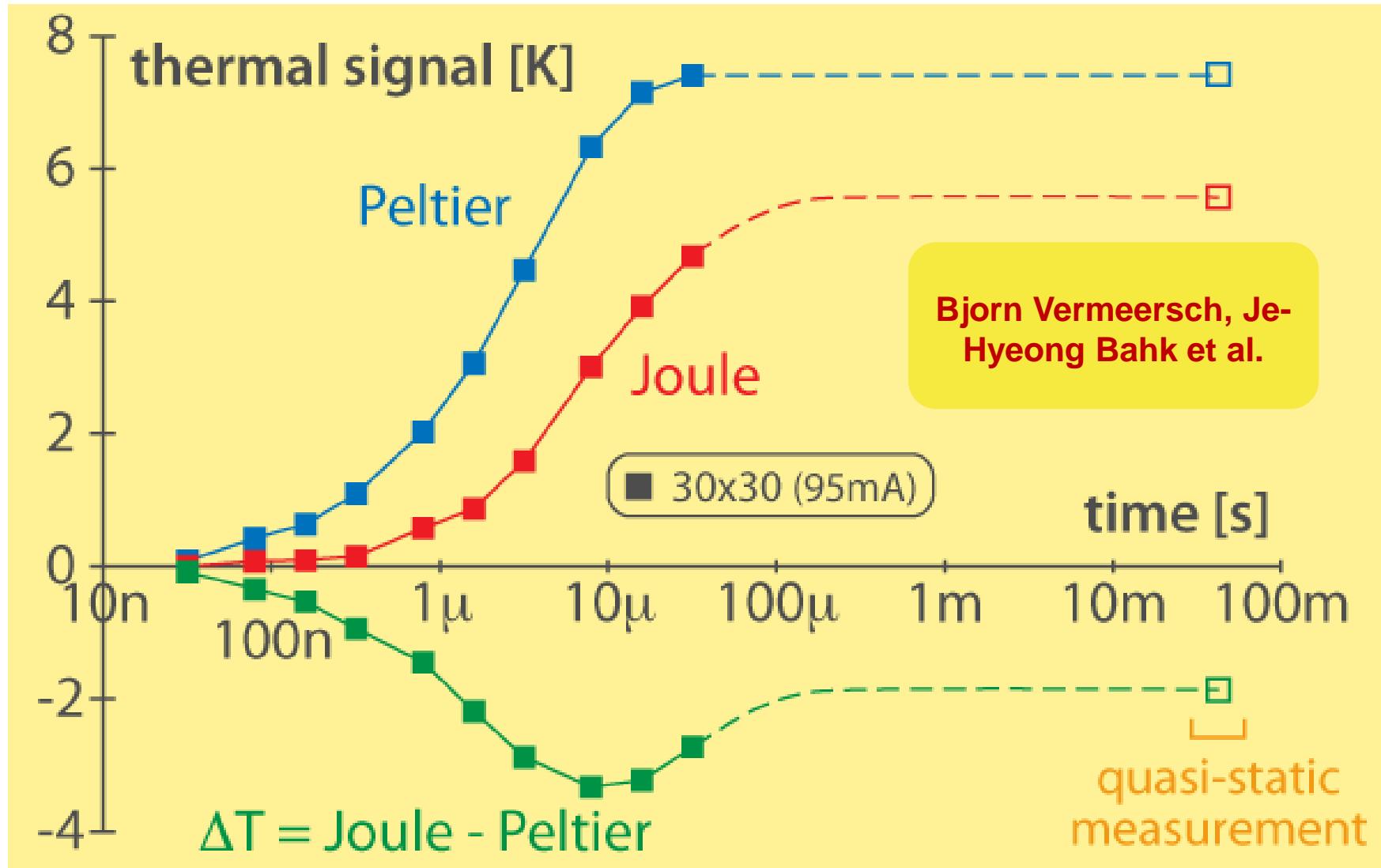
Nanoscale heat transport and microrefrigerators on a chip; A. Shakouri,  
Proceedings of IEEE, July 2006

# High resolution thermal imaging of microcoolers

- Temperature resolution:  $0.006^{\circ}\text{C}$
- Spatial resolution: **submicron**
- 256 channel lock-in camera <20kHz, 123dB (1sec)



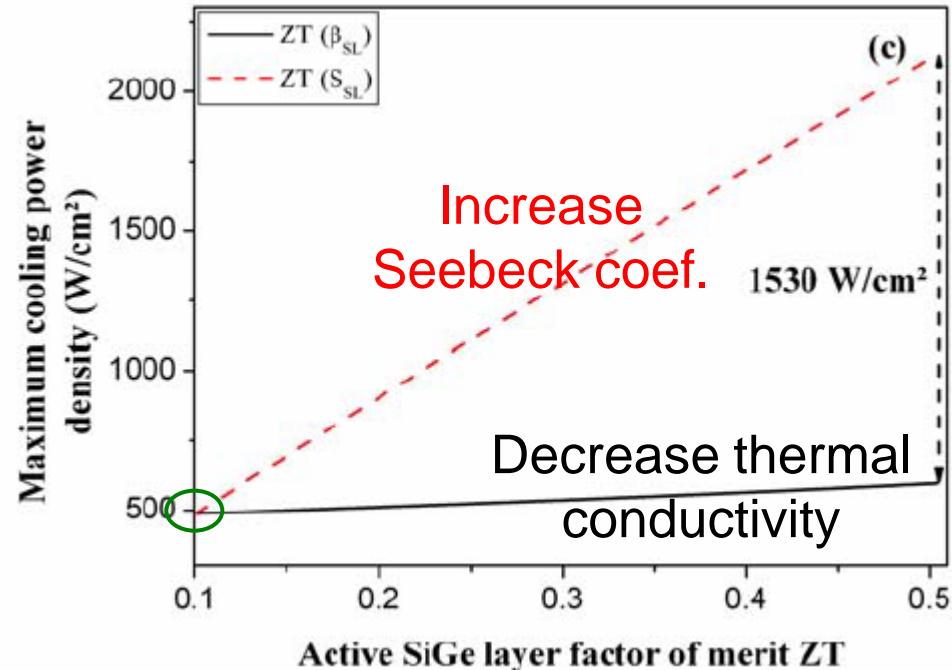
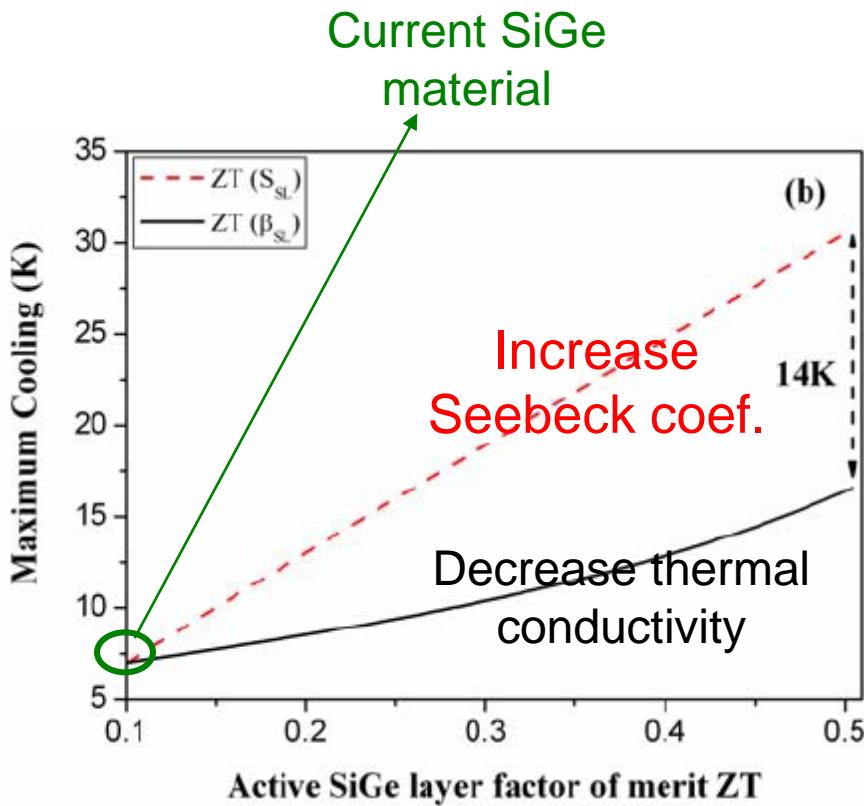
# Transient thermal imaging



- Maximum cooling can be increased under pulsed operation
- Reason: Interface Peltier cooling and distributed Joule

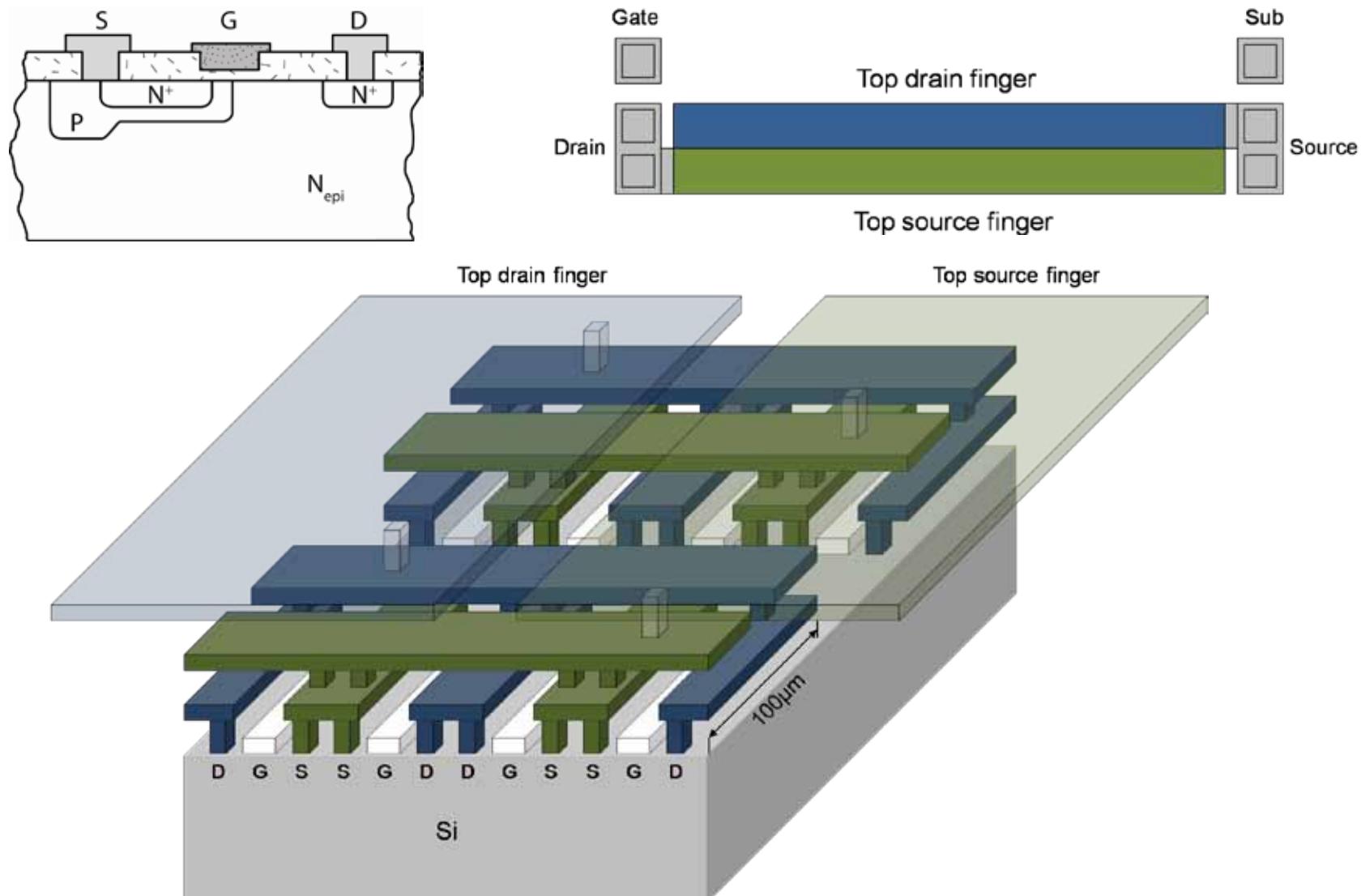
# Thin Film Microrefrigerator Optimization

- 10 microns thick, 50x50mm<sup>2</sup> monolithic microrefrigerator with ZT~0.5 can cool a 1000W/cm<sup>2</sup> hot spot by >15C.



# Ultrafast Thermal Characterization and Simulations Techniques

# High Power MOSFET Transistor Array

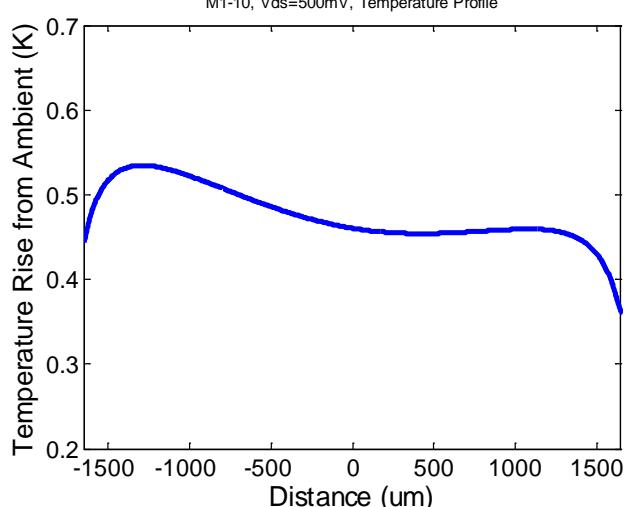
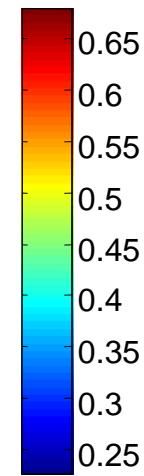
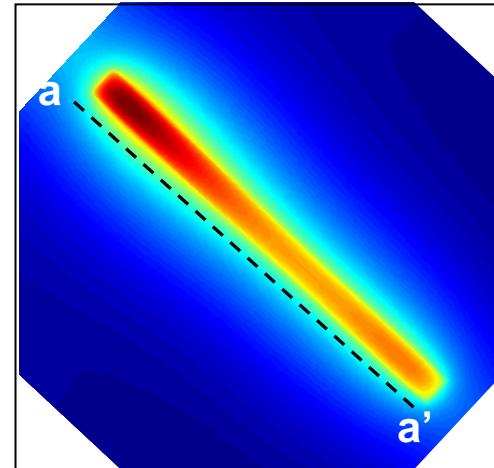
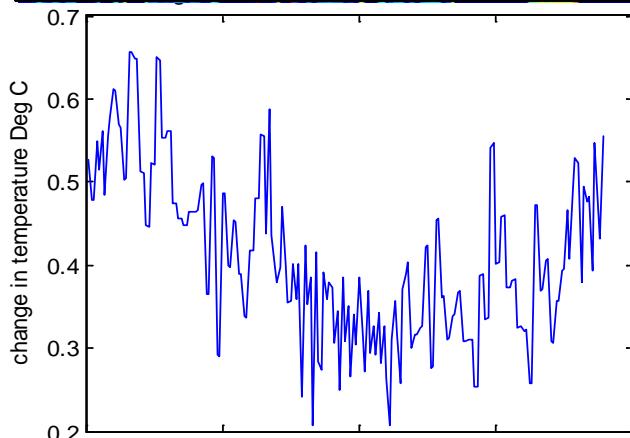
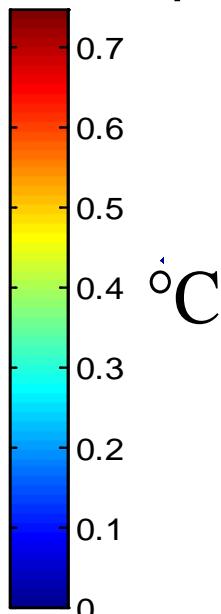
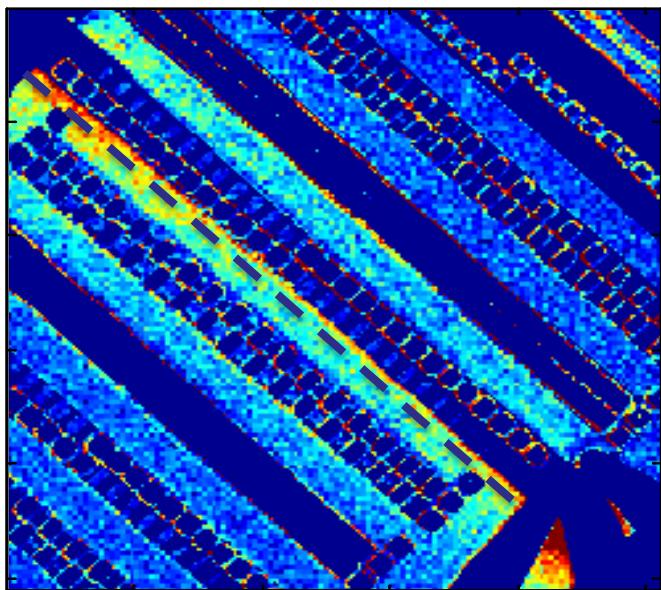


“Thermal Characterization of High Power Transistor Arrays”, K. Maize et al,  
25th IEEE SEMI-THERM Symposium, 2009.

# Thermal image vs. simulation at low bias

$V_d = 0.5V$ ,  $I_d \approx 0.5A$

6 amps/mm<sup>2</sup>

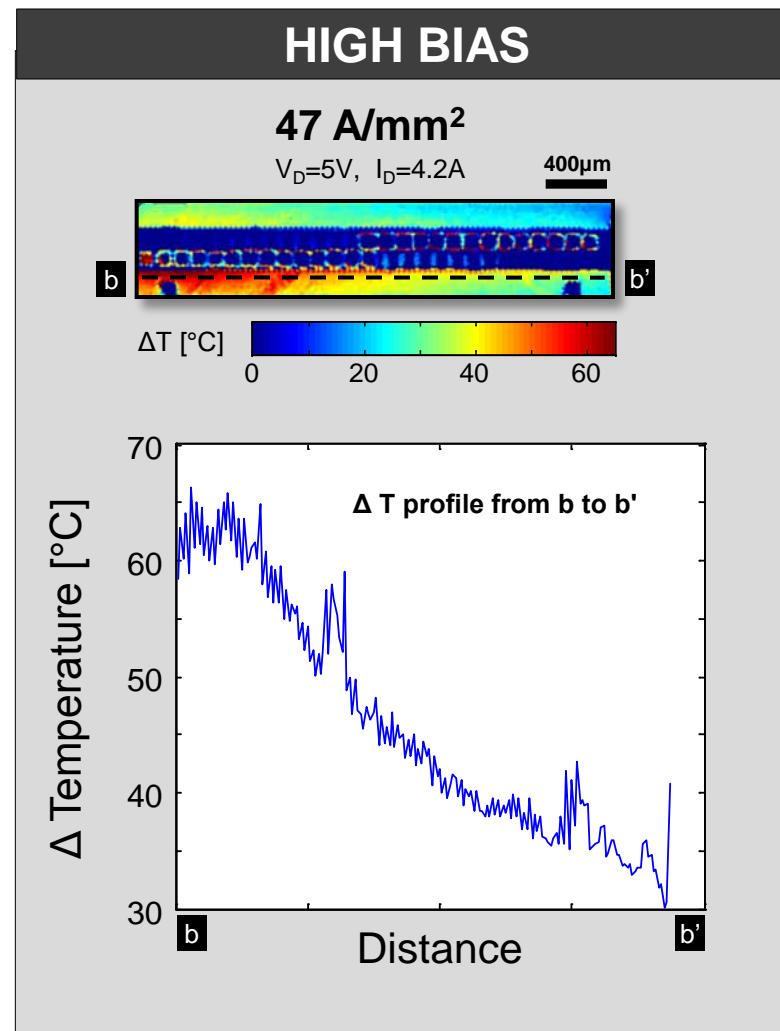
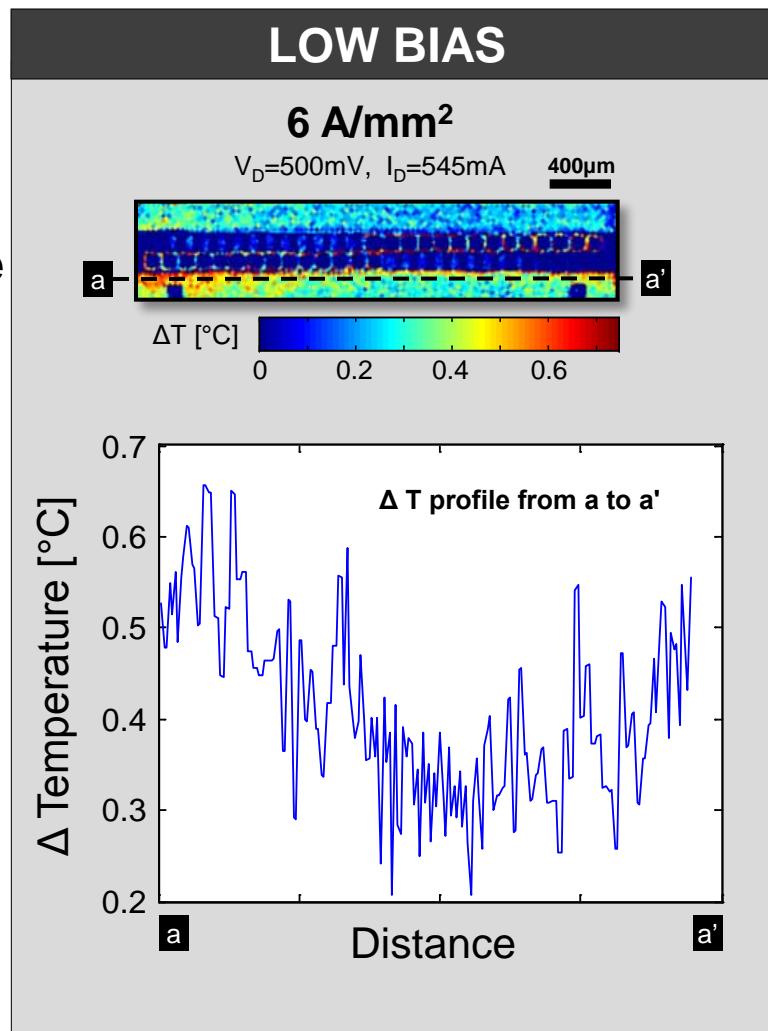


The magnitudes of temperature rise at both ends (source and drain ) are in a good agreement. Potential role of the probe tips.

# Array heating at low & high current densities

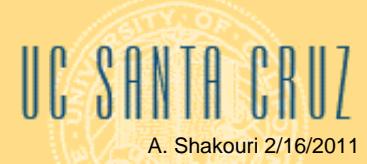
Thermo-  
reflectance  
thermal  
images

Tempera-  
ture  
profile  
along  
array

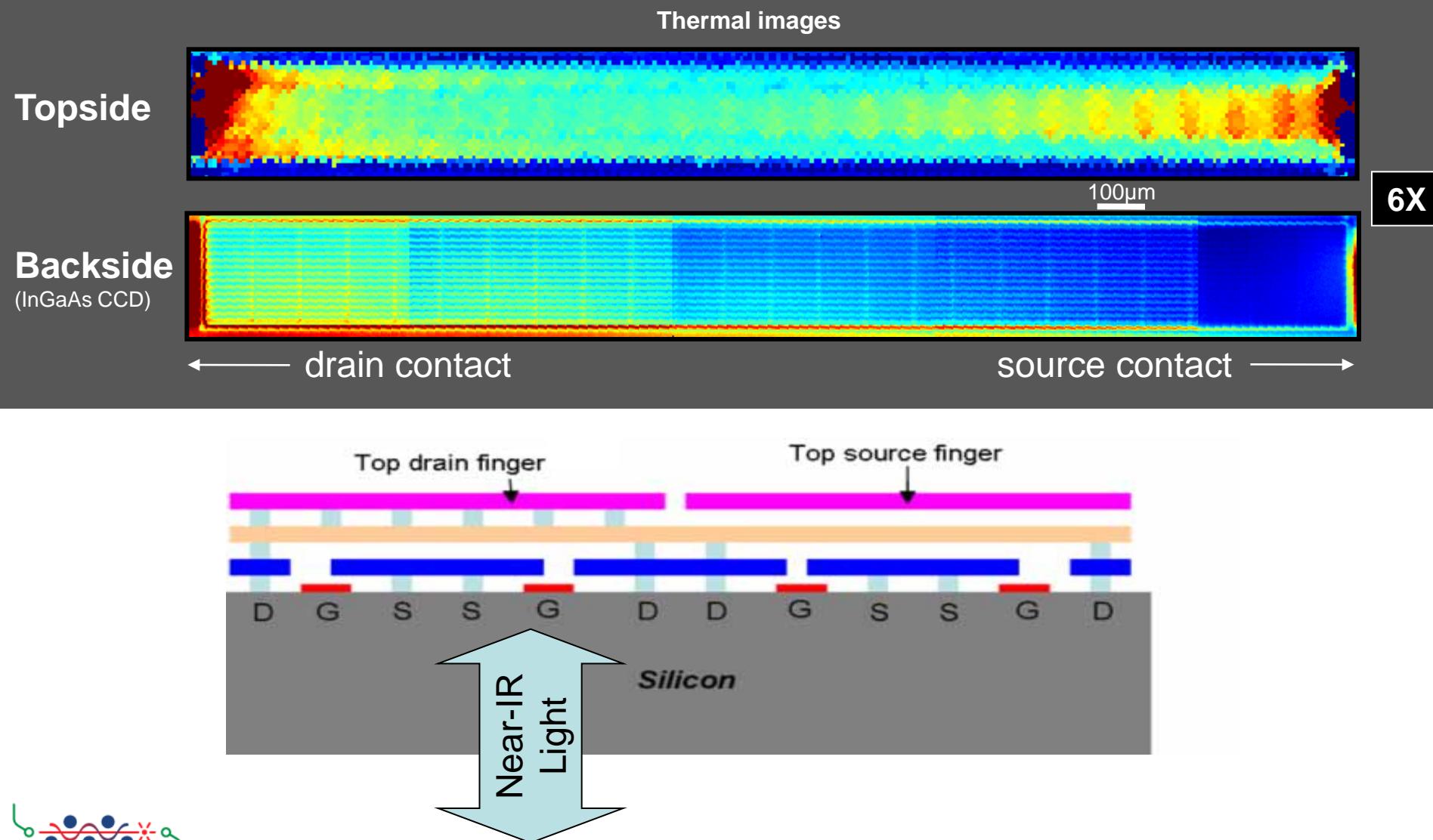


"Thermal Characterization of High Power Transistor Arrays", K. Maize et al,  
25th IEEE SEMI-THERM Symposium, 2009.

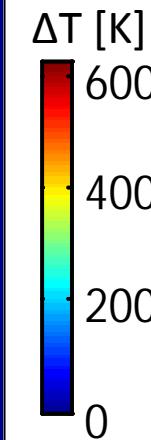
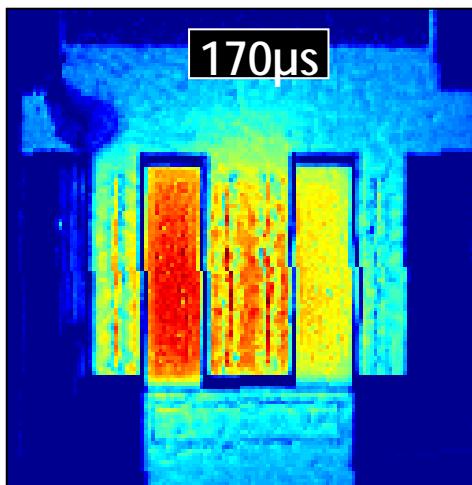
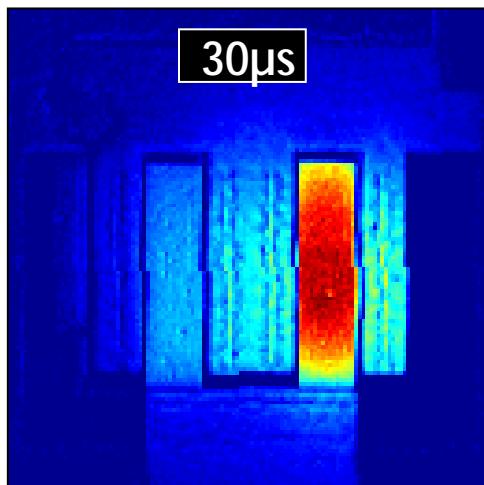
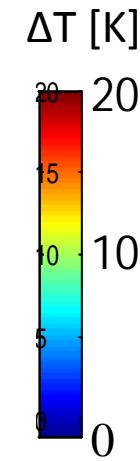
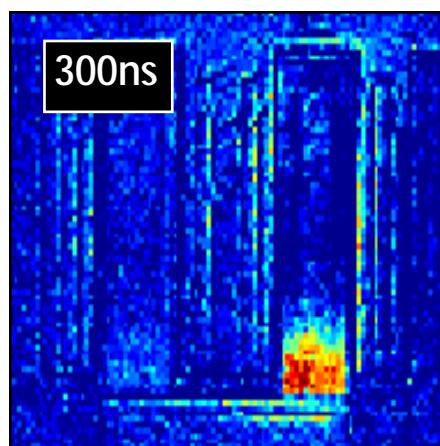
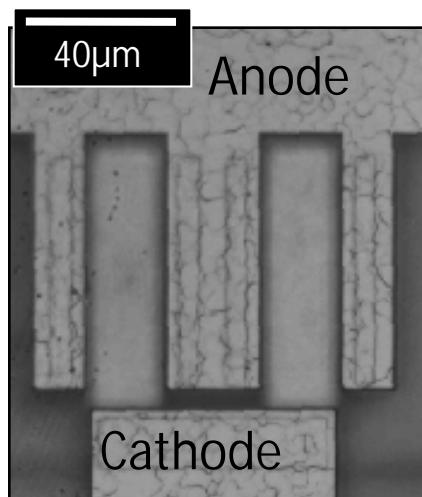
# Through-substrate thermoreflectance – Comparing topside and backside heating



A. Shakouri 2/16/2011



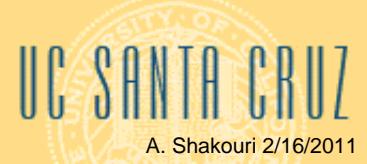
# Heating in Electro Static Discharge Devices



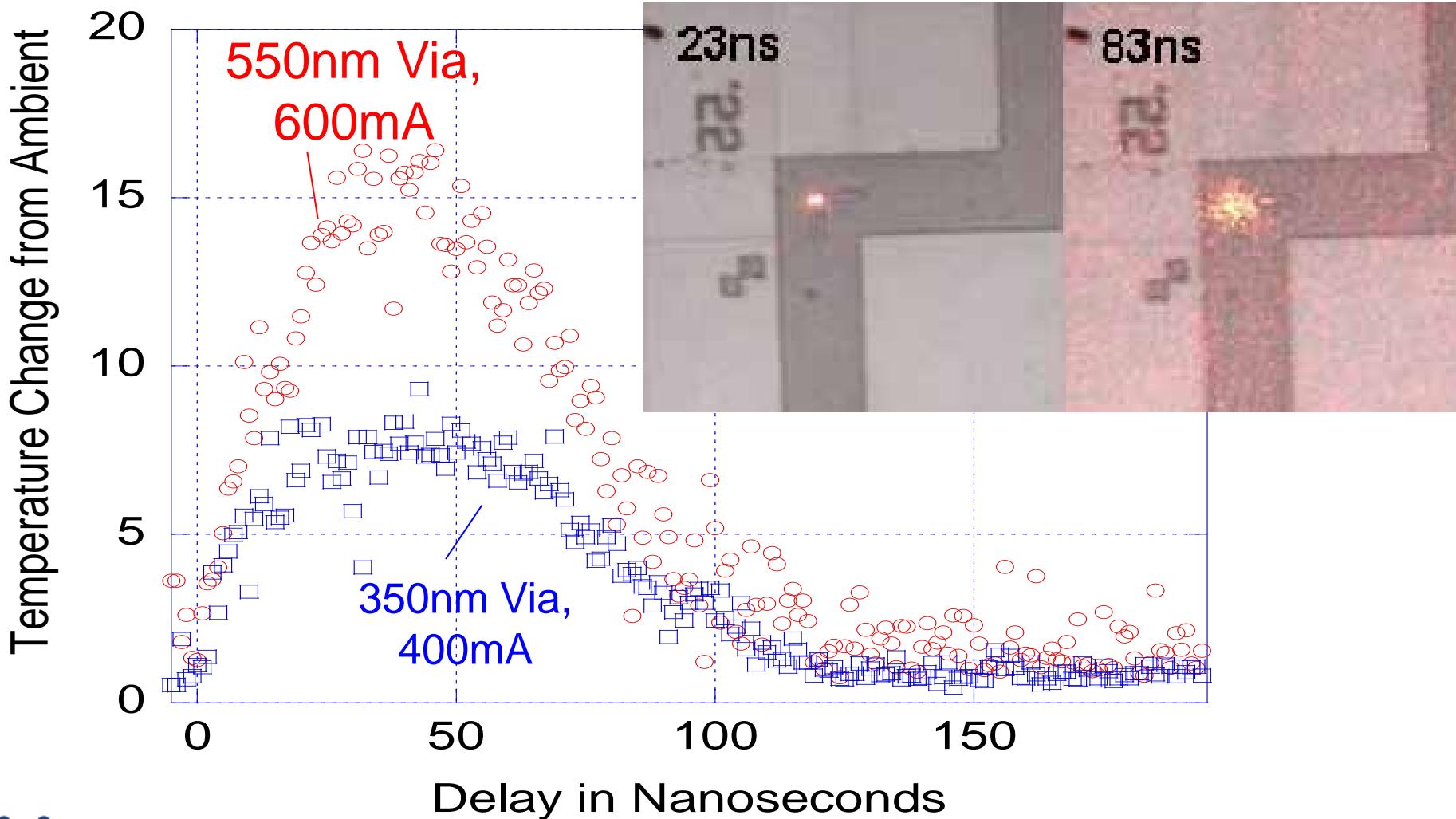
Snapback current = 1.22A.

K. Maize, V. Vashchenko et al, *To be presented at IRPS, 2011.*

# High Speed Thermal Imaging (800ps)



## Study of heating in submicron interconnect vias



J. Christofferson et al., *Proceedings of Int. Heat Transfer Conf.*, August 2010

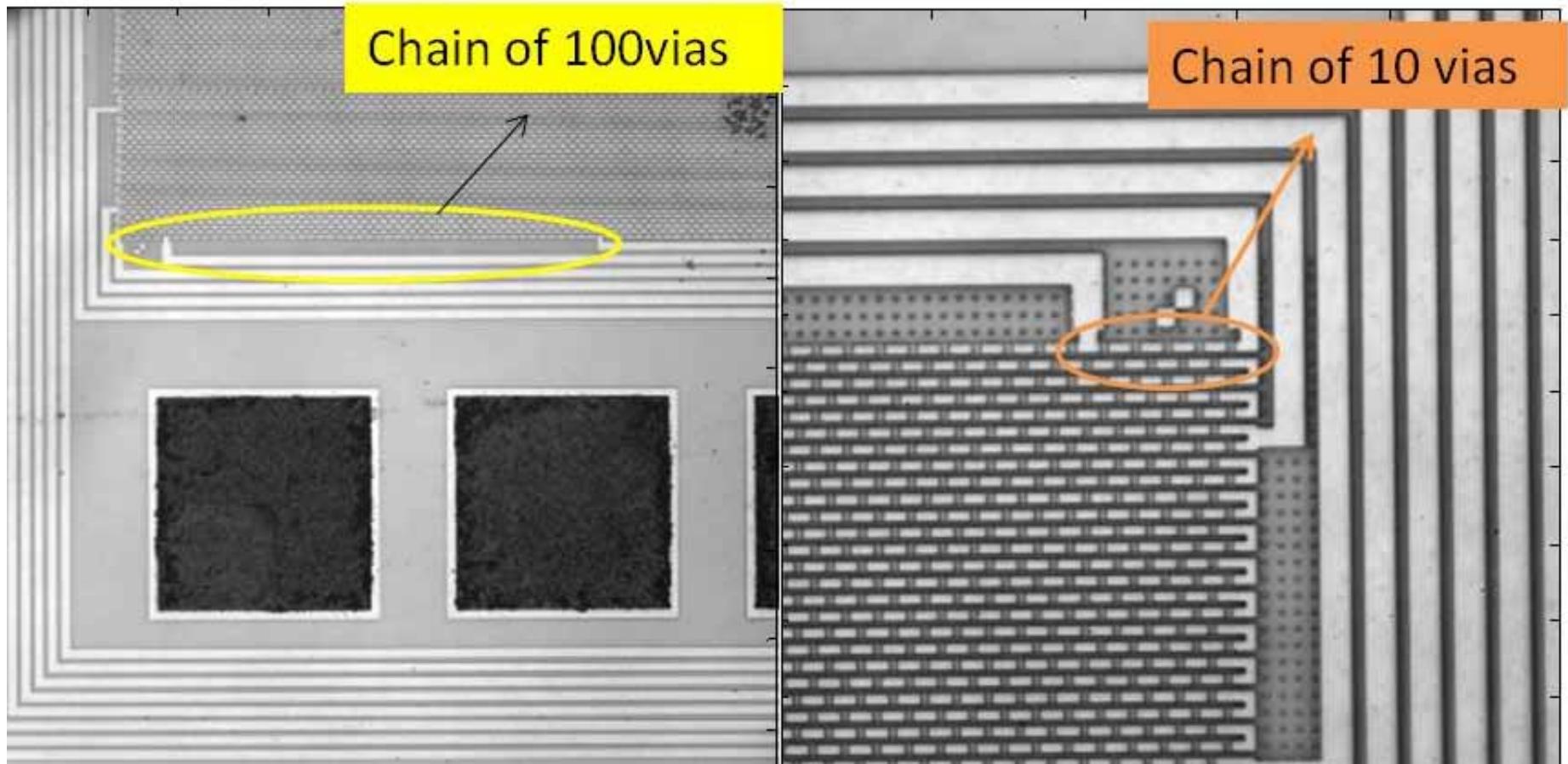
# Thermoreflectance Imaging for Reliability Characterization of Copper Vias

Shila Alavi, Glenn B Alers, Kaz Yazawa  
and Ali Shakouri

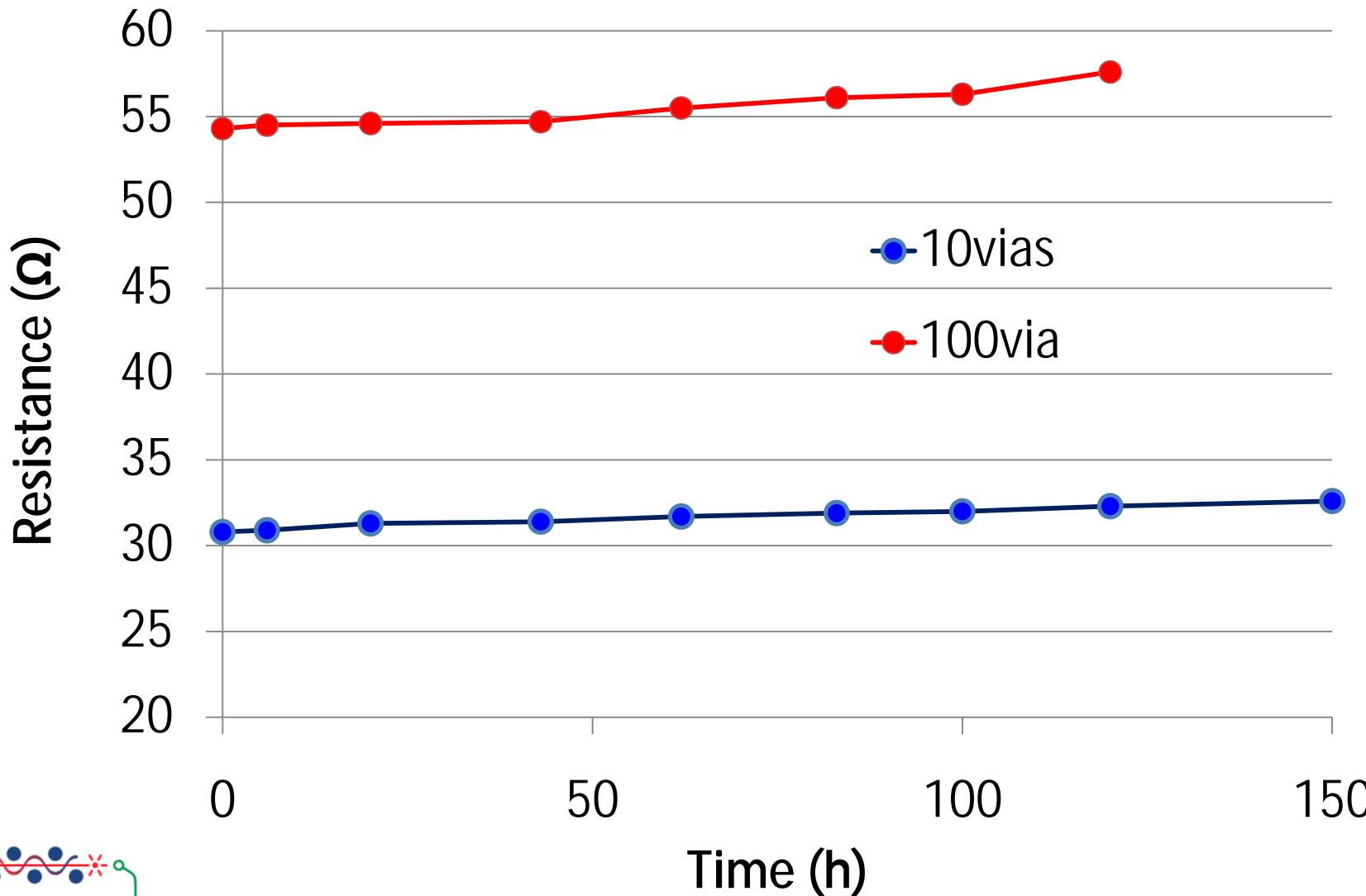
Department of Electrical Engineering  
University of California, Santa Cruz

Advanced Studies Laboratory  
University of California, Santa Cruz

# Copper via chains

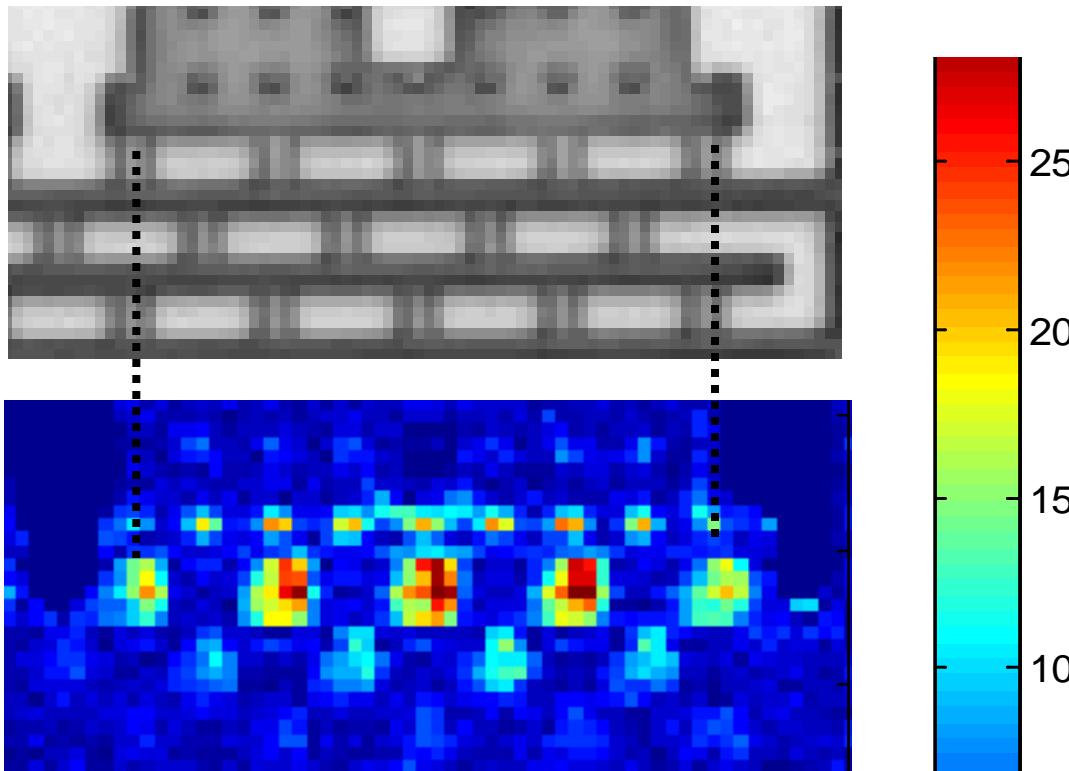


# Resistance shift for different via chains after aging at 200C

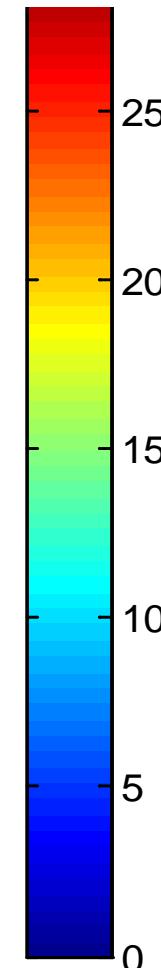
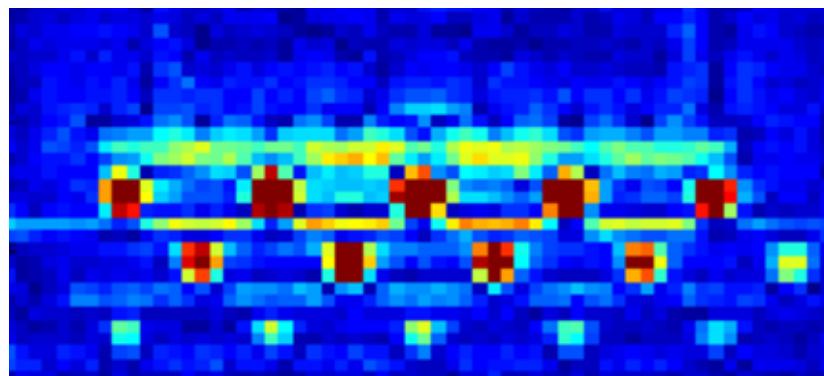


# Thermal map of 10 via chain under bias

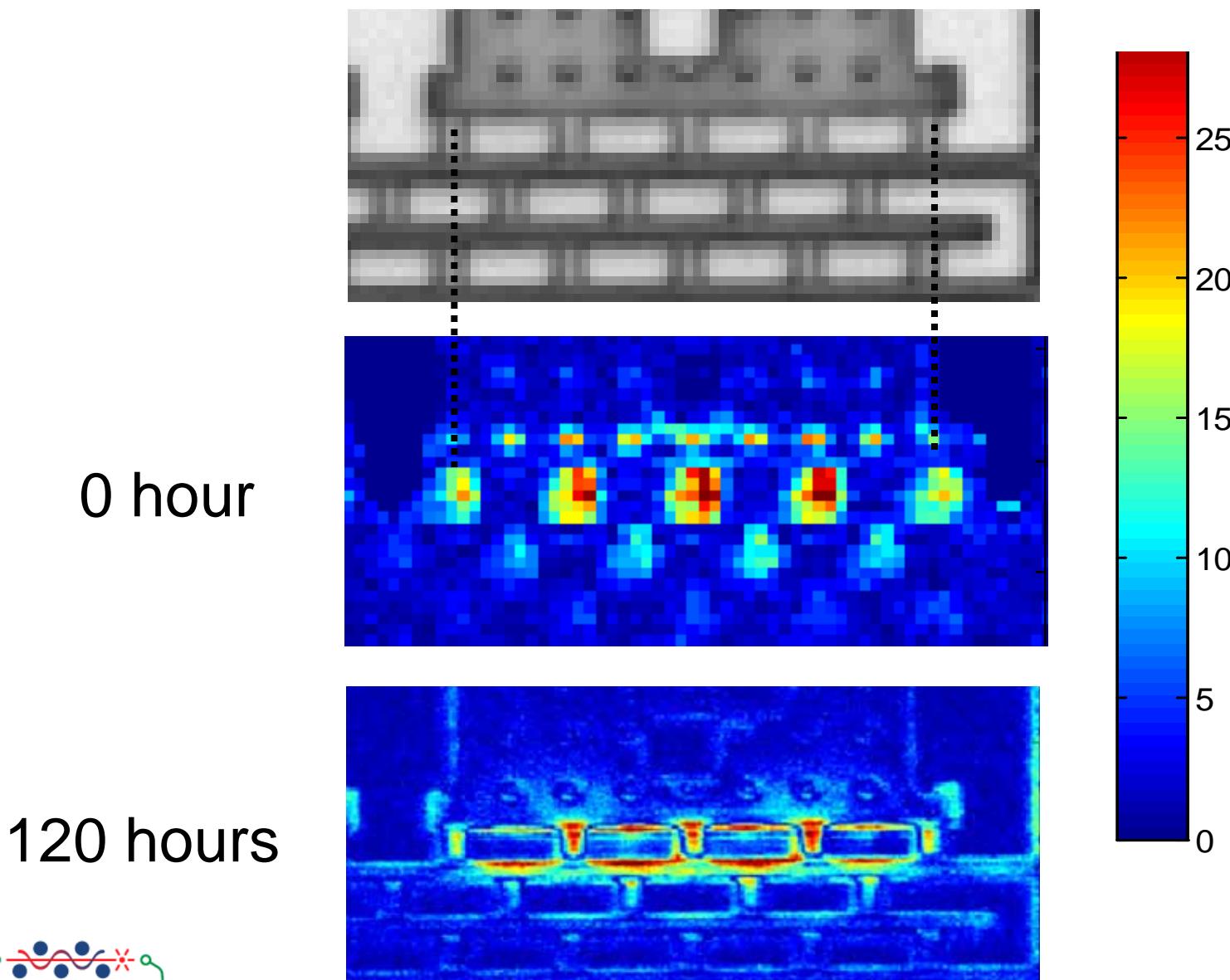
0 hour



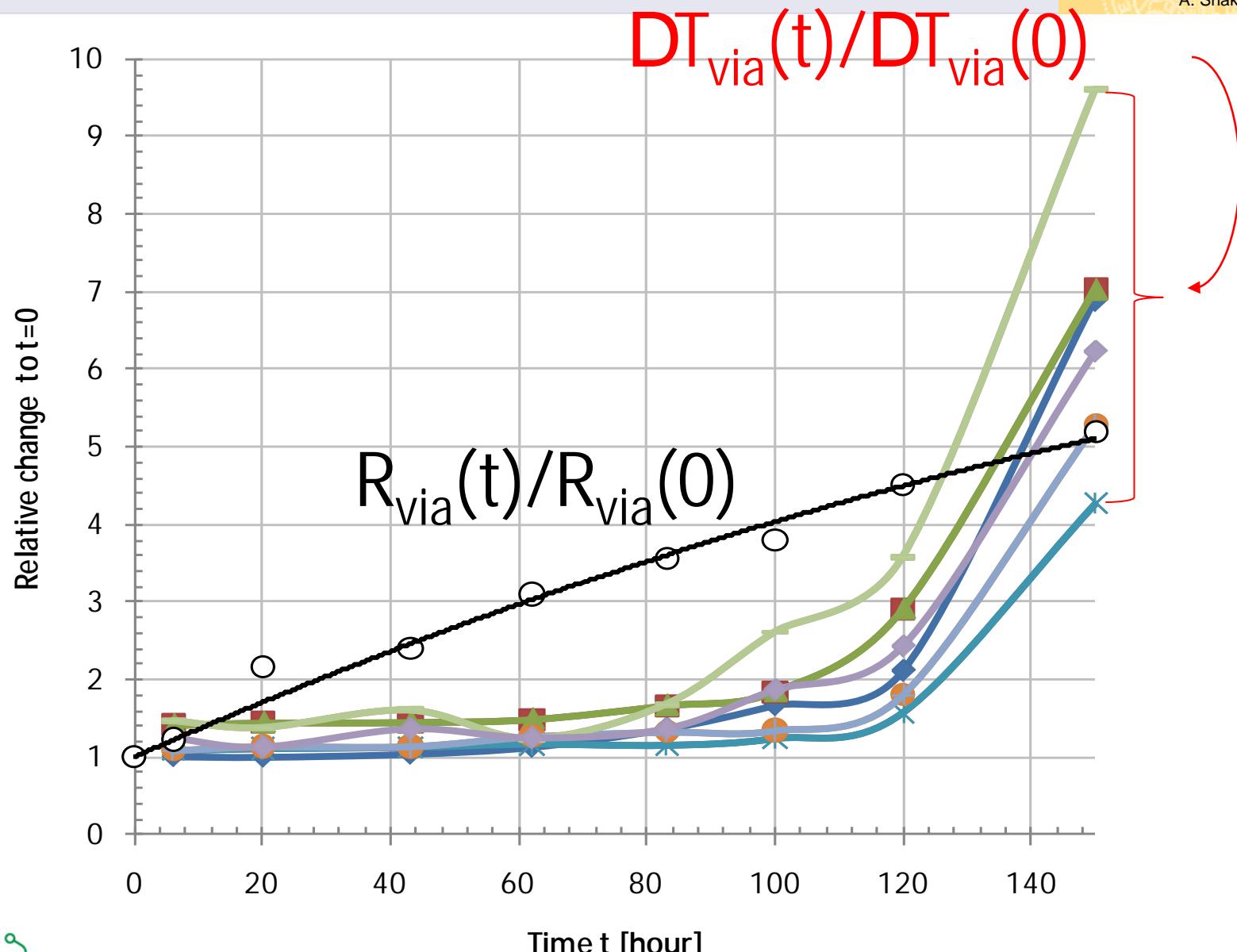
83 hours



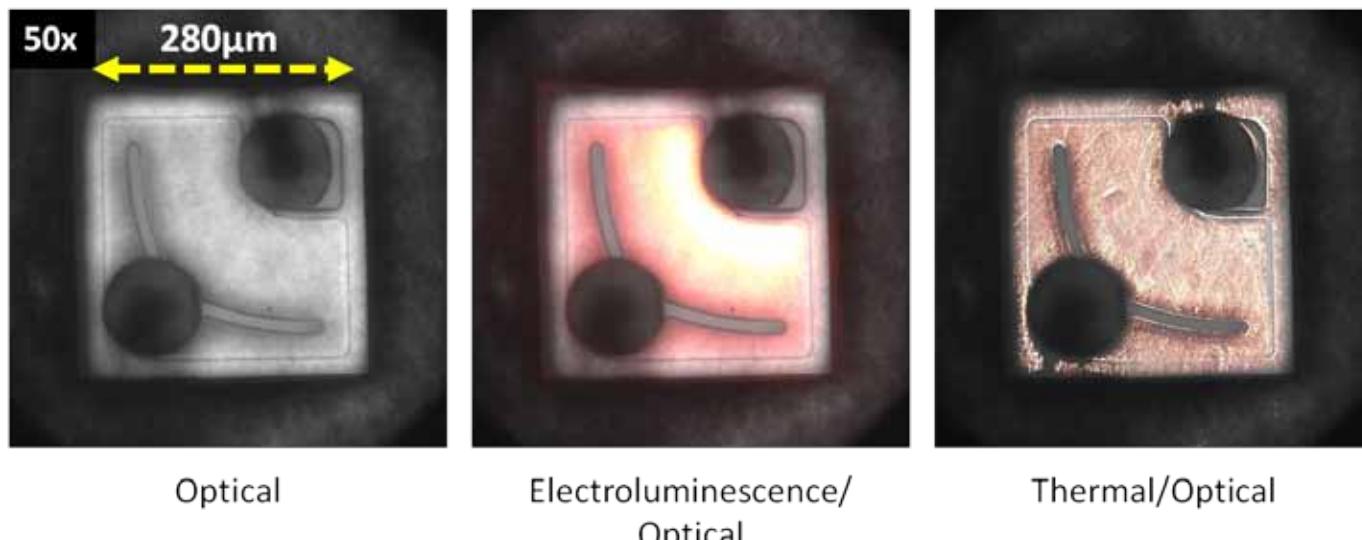
# Thermal map of 10 via chain under bias



# Relative change in R and DT



# Thermal/ electroluminescence imaging of LEDs

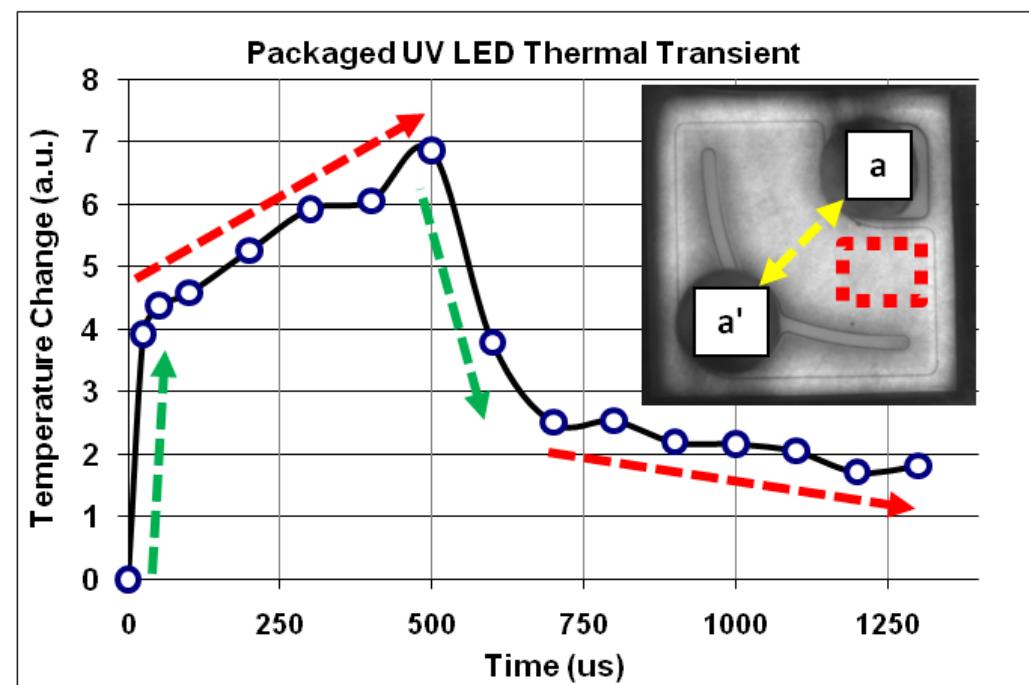


Optical

Electroluminescence/  
Optical

Thermal/Optical

D. Kendig et al, *To be presented at SemiTHERM, 2011*



# Thermal/ electroluminescence imaging of Solar cells

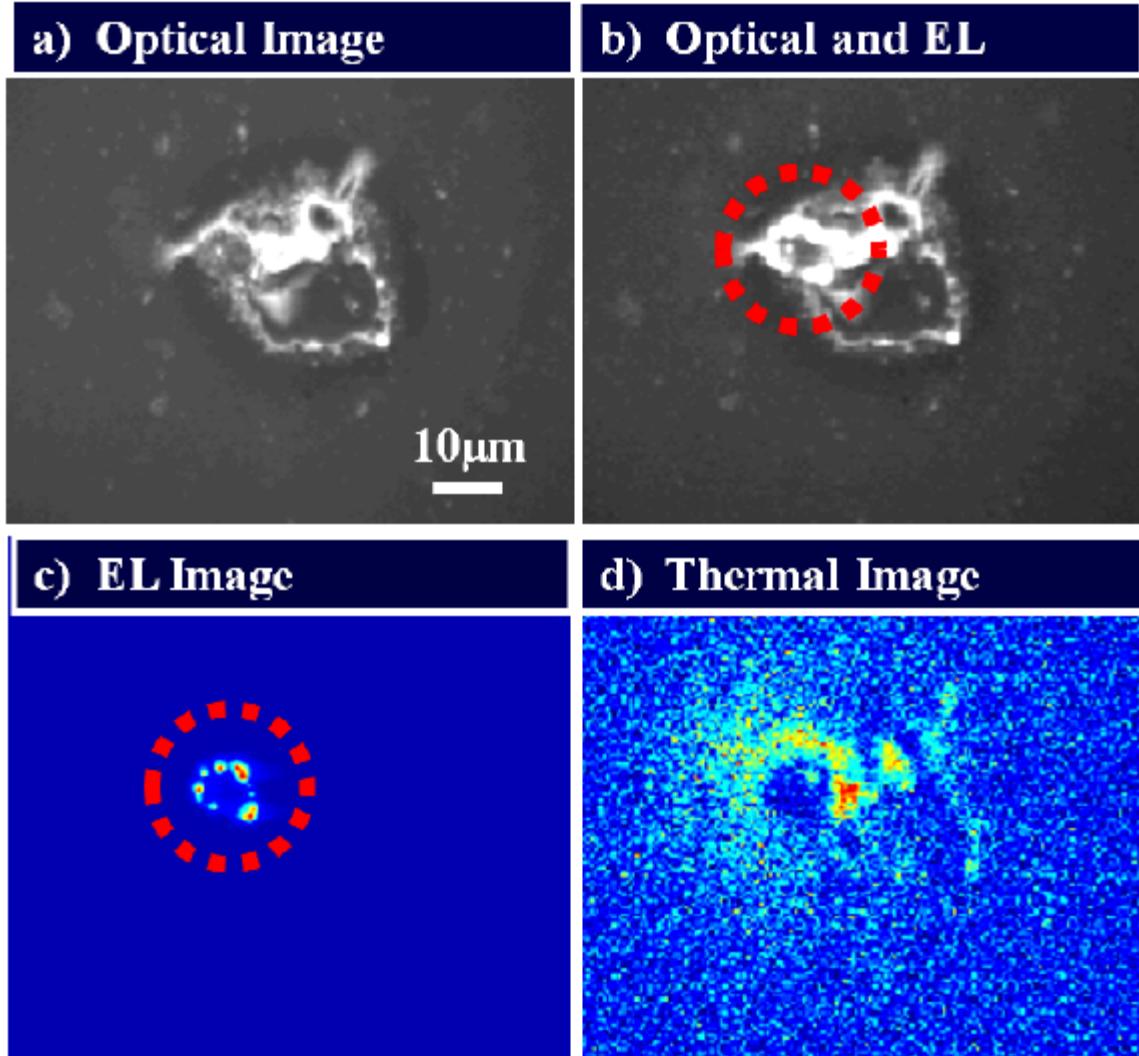
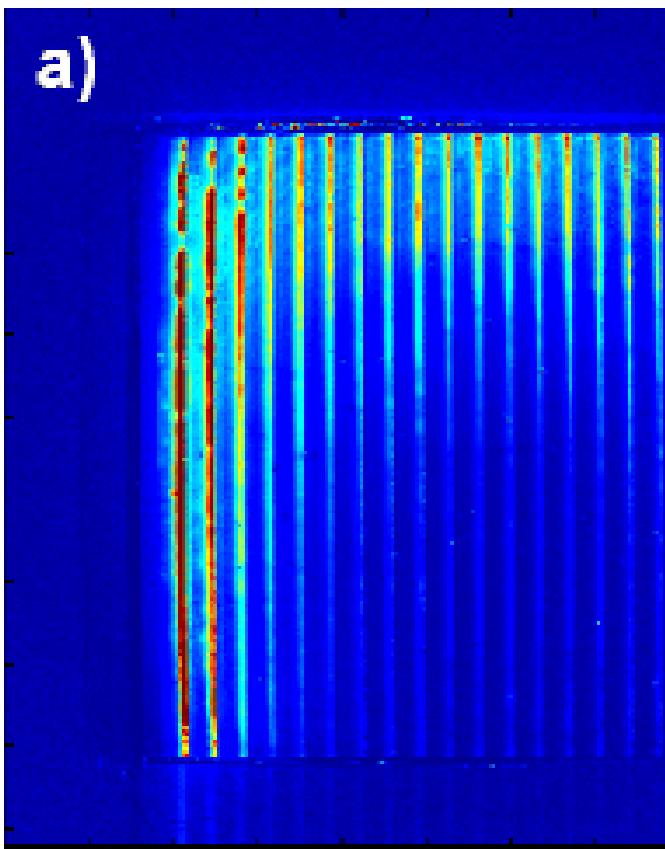


Figure 4. a) forward and b) reverse bias thermal/electroluminescence images of a solar cell mini-rib.

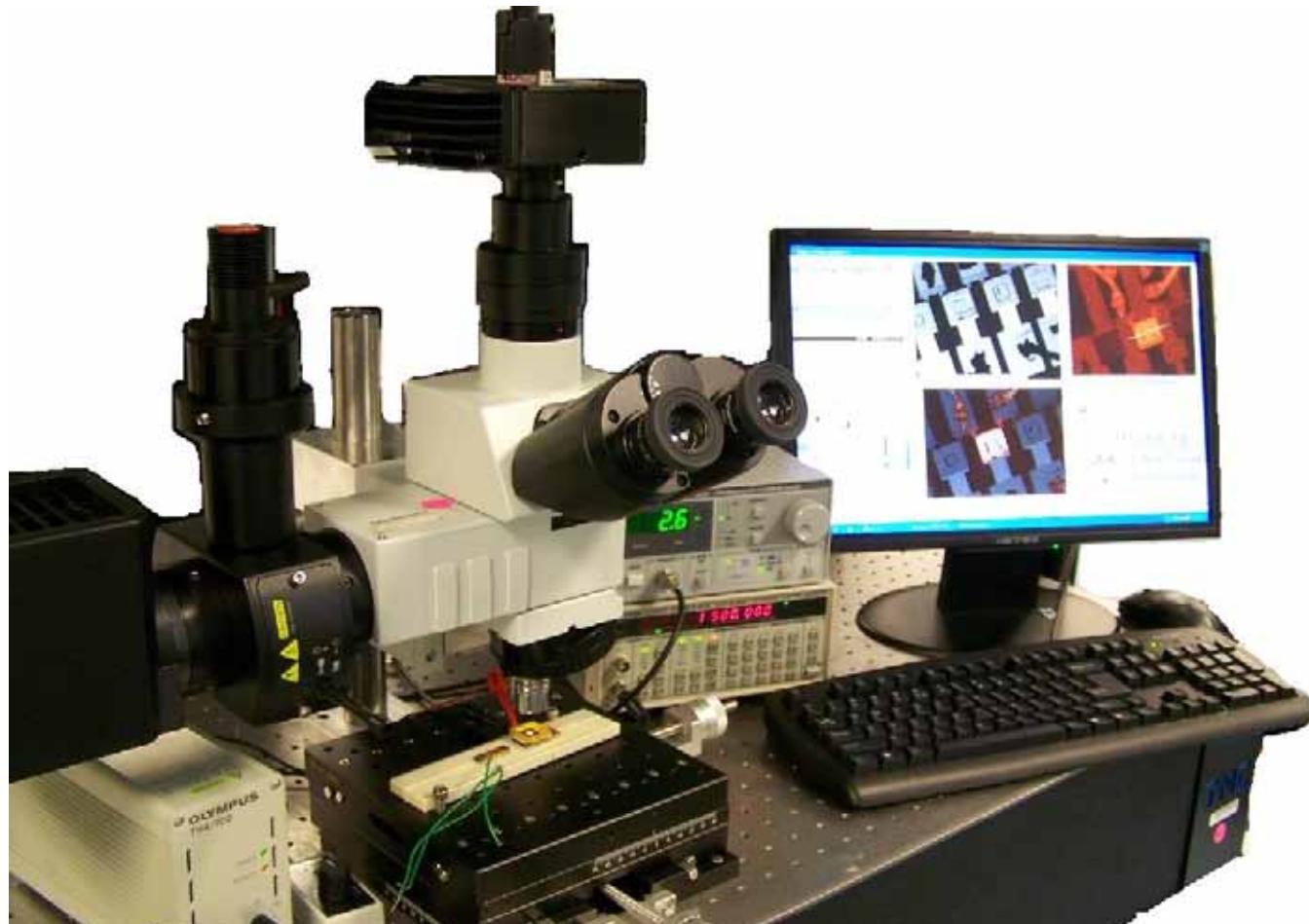
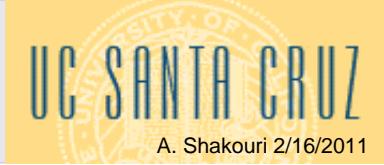
D. Kendig et al,  
IPRS 2010

Figure 6. a) optical image of a defect in poly-Si, b) optical image with EL combined to show the location of the EL on the defect, c) EL signal in reverse bias, d) Thermal image of defect at 30V reverse bias

# Technology Transition:

Stand alone thermoreflectance imaging system

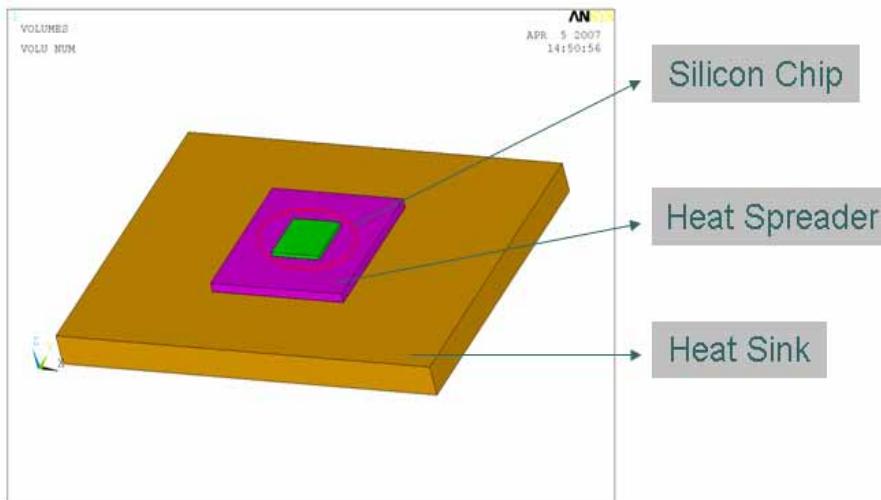
(resolution: **200nm**, **100ns**, **0.2C**, pixels: **1024x1022**)



Thermal Imaging Analyzer NT200T  
[Microsanj.com](http://Microsanj.com)

# Ultrafast Thermal Simulation Techniques

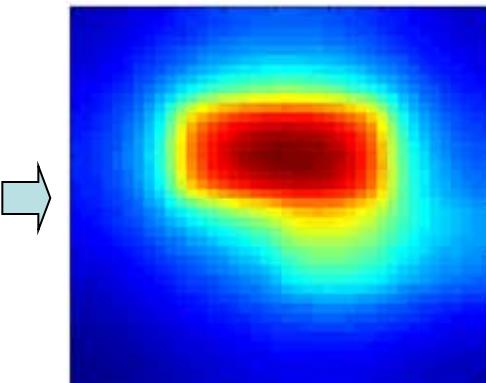
# THERMAL SIMULATION APPROACHES



Power Map

4W	4W	4W	4W
4W	16W	16W	4W
4W	4W	8W	6W
4W	4W	4W	4W

Temperature Profile



## Heat Equation

$$rc_p \frac{\nabla T}{\nabla t} = k \frac{\nabla^2 T}{\nabla x^2} + k \frac{\nabla^2 T}{\nabla y^2} + k \frac{\nabla^2 T}{\nabla z^2} + q^*$$

$T$  = temperature

$t$  = time

$k$  = thermal conductivity

$\rho$  = density

$c_p$  = heat capacity

$q^*$  = heat generation rate per unit volume

## Approaches

✓ Finite Difference Method

✓ Finite Element Method

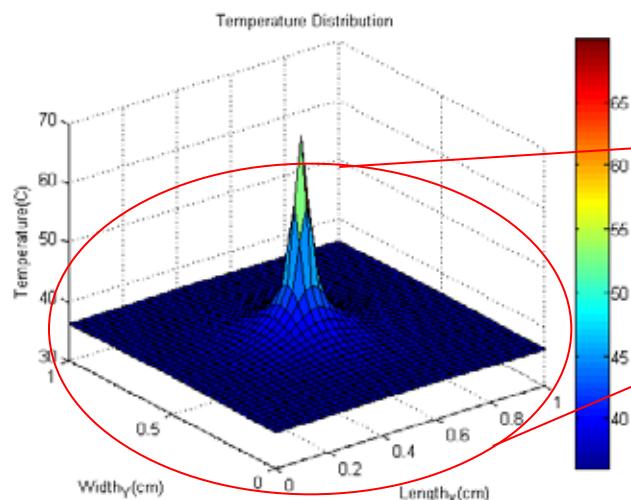
✓ *Green's Function Method*

=> *Analogy with image blurring (power blurring)*

# HEAT SPREADING FUNCTION (THERMAL MASK)

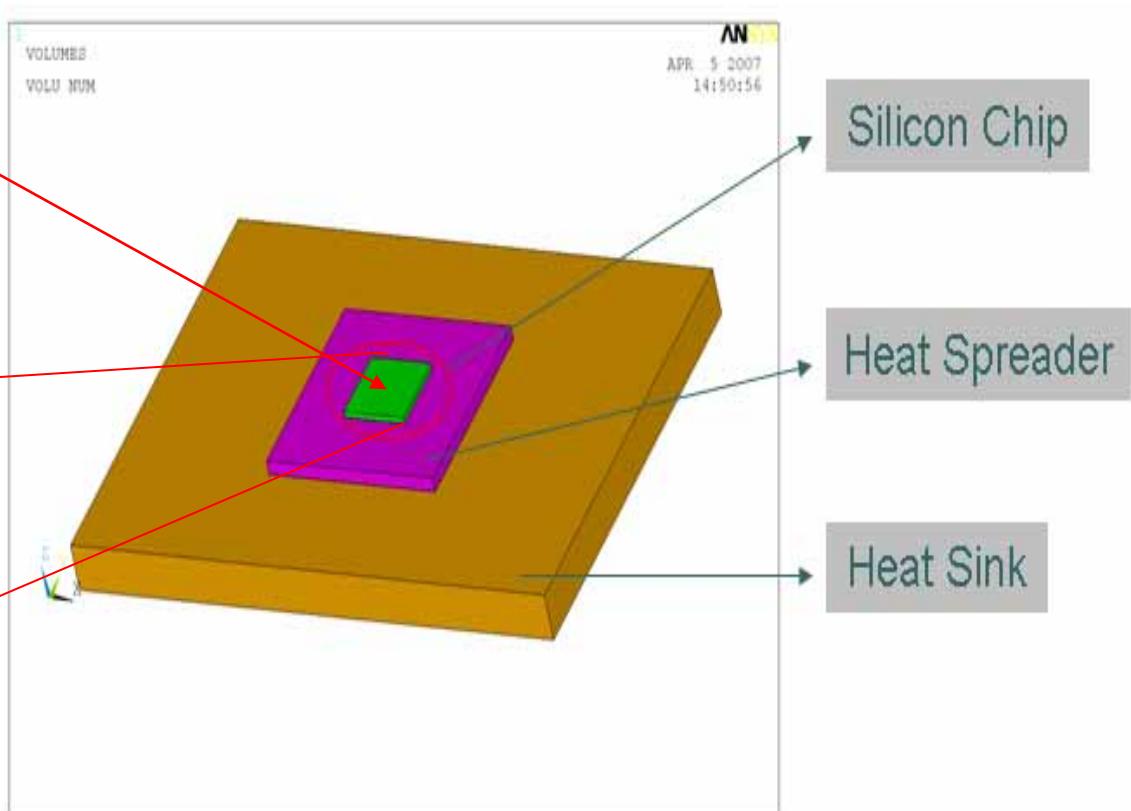
## Finite Element Analysis

Apply Point Heat Source



normalization

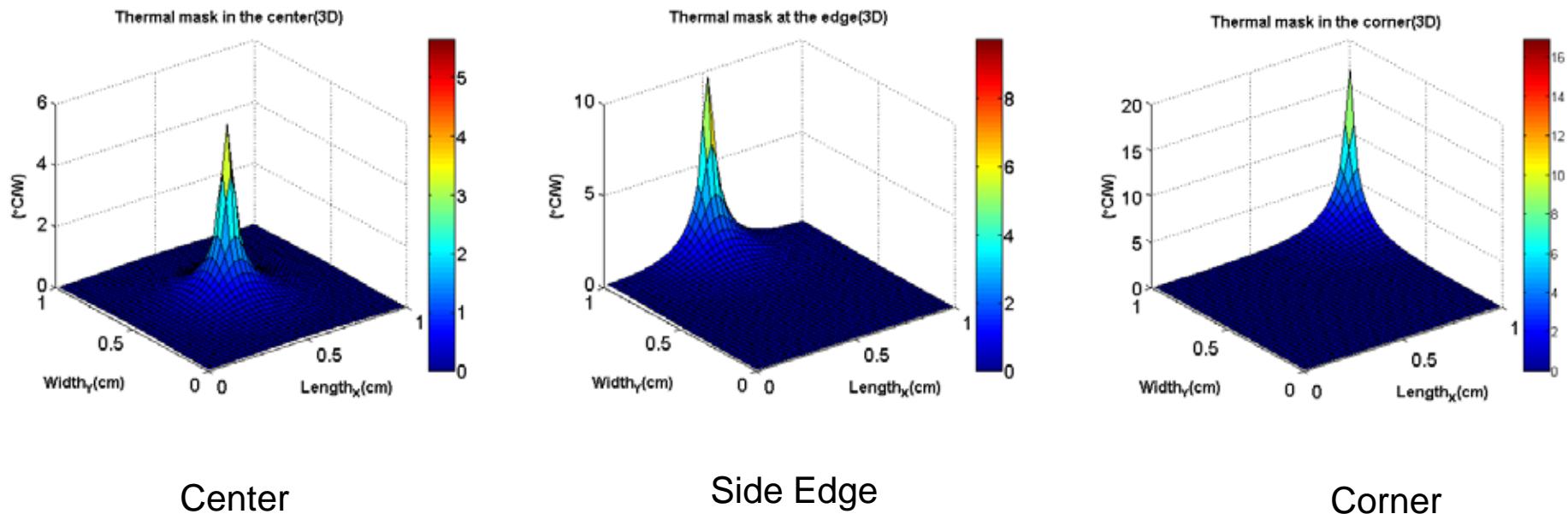
→ Thermal Mask



Package Model

# BOUNDARY EFFECTS

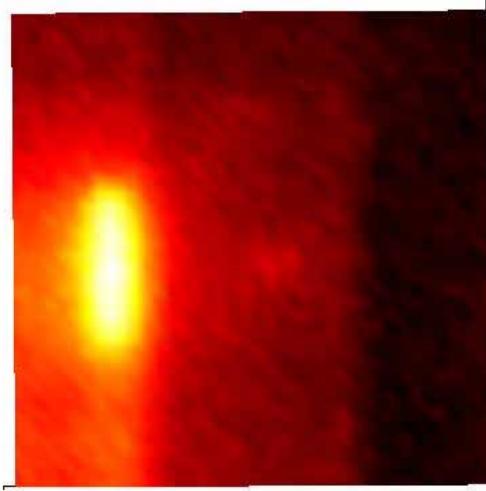
Due to the finite dimension of the Si-Chip, boundary effect is important.  
=> simplification: Use Method of Images and uniform heat compensation



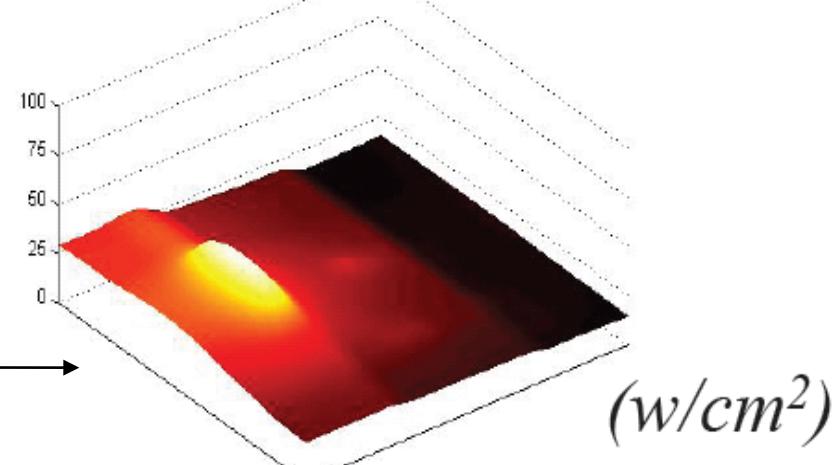
V. Heriz, J.-H. Park, T. Kemper, S.-M. Kang, A. Shakouri, International Workshop on Thermal Investigation of ICs and Systems (Therminic), pp.18-25 Sept. 2007  
A. Shakouri et al. US Patent 7,627,841

# Inverse problem (temperature -> power)

Measured temperature profile (include noise)

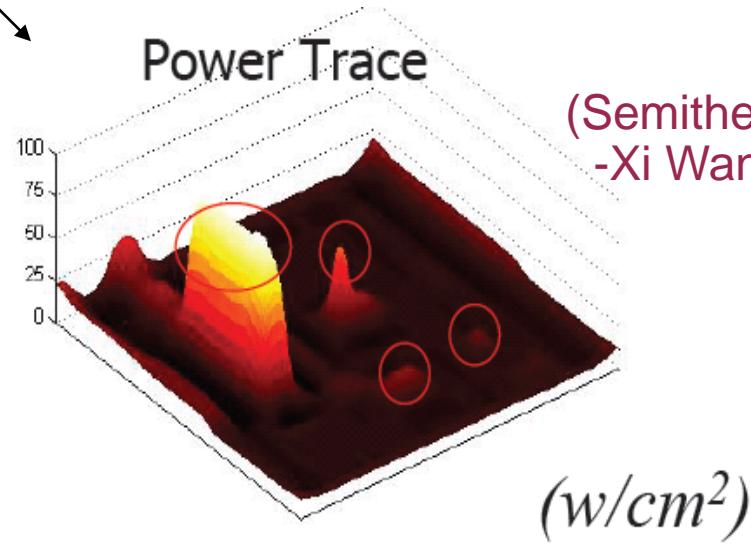


Direct inverse



Power Trace

(Semitherm 2007  
-Xi Wang et al.)



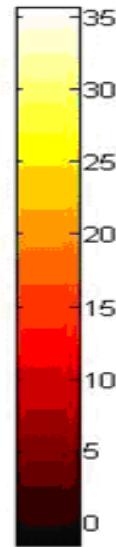
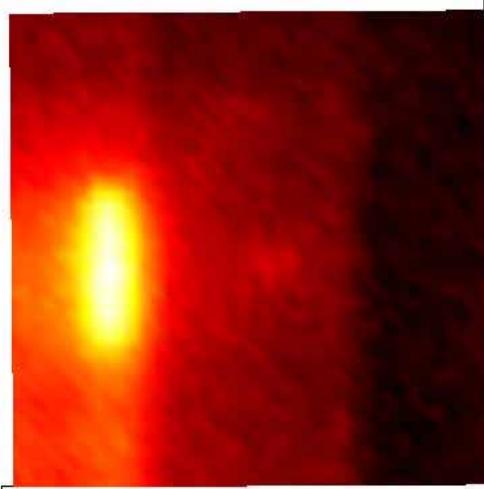
## IMAGE DEBLURRING

REGULARIZATION:

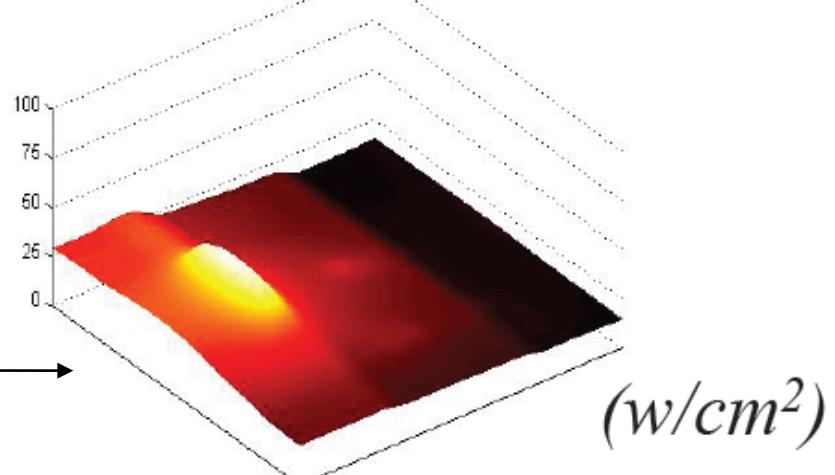
- Tikhonov Regularization (does not preserve edges)
- Bilateral Total Variation (Maximum a Posteriori Cost function) Farsiu, et al. IEEE Trans on Image Processing, 13 (10), p. 1327 October, 2004.

# Inverse problem (temperature -> power)

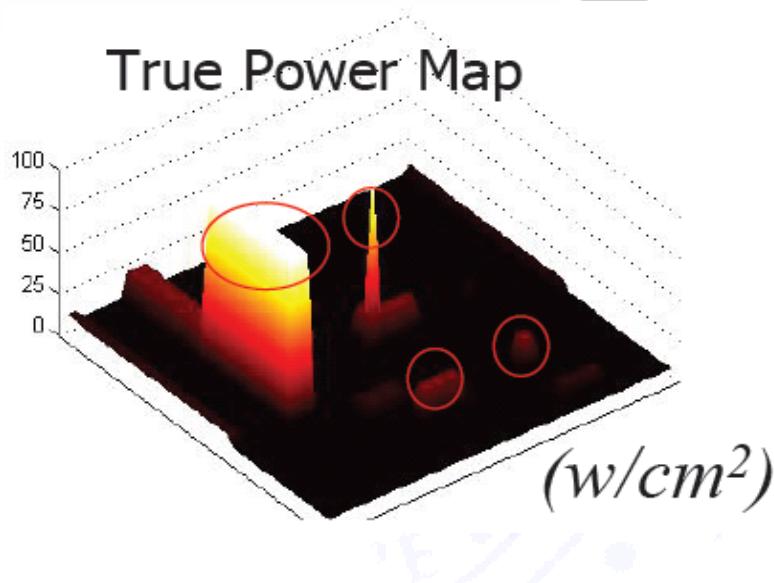
Measured temperature profile (include noise)



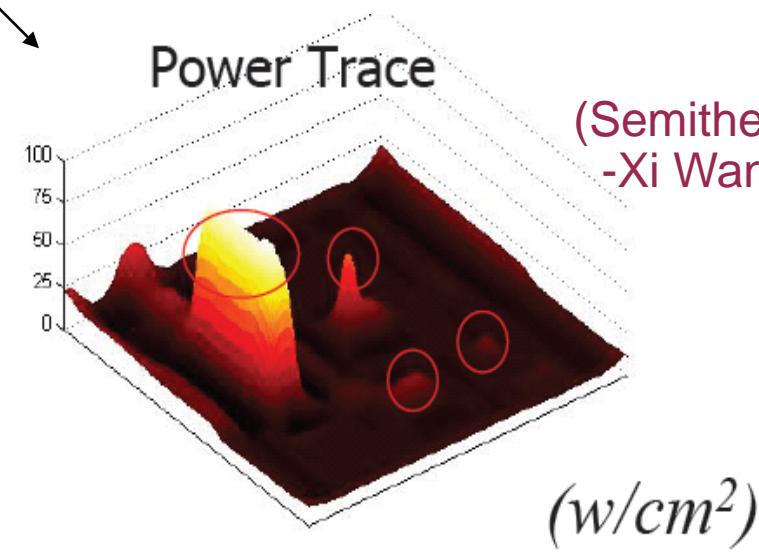
Direct inverse



True Power Map

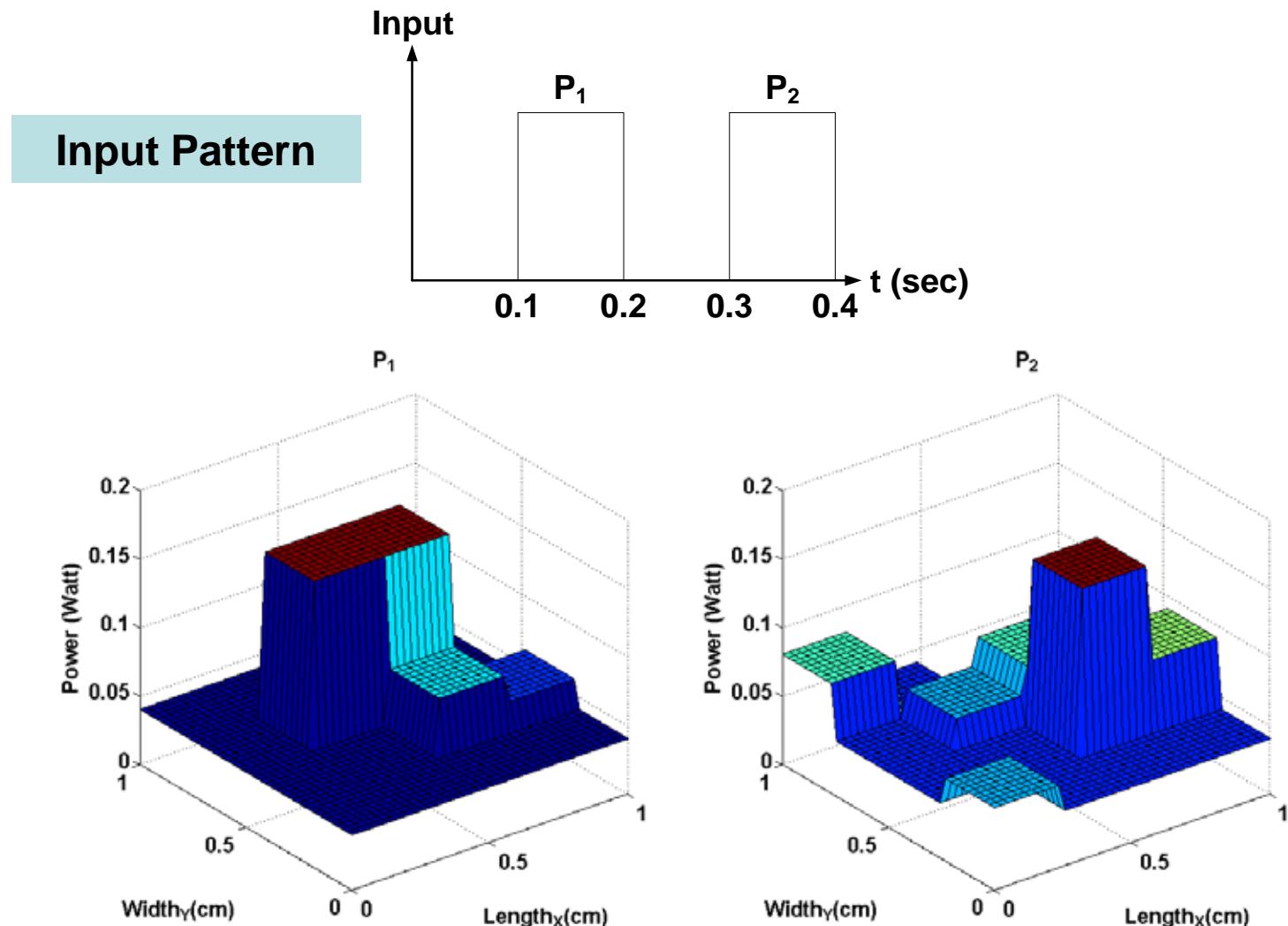


Power Trace

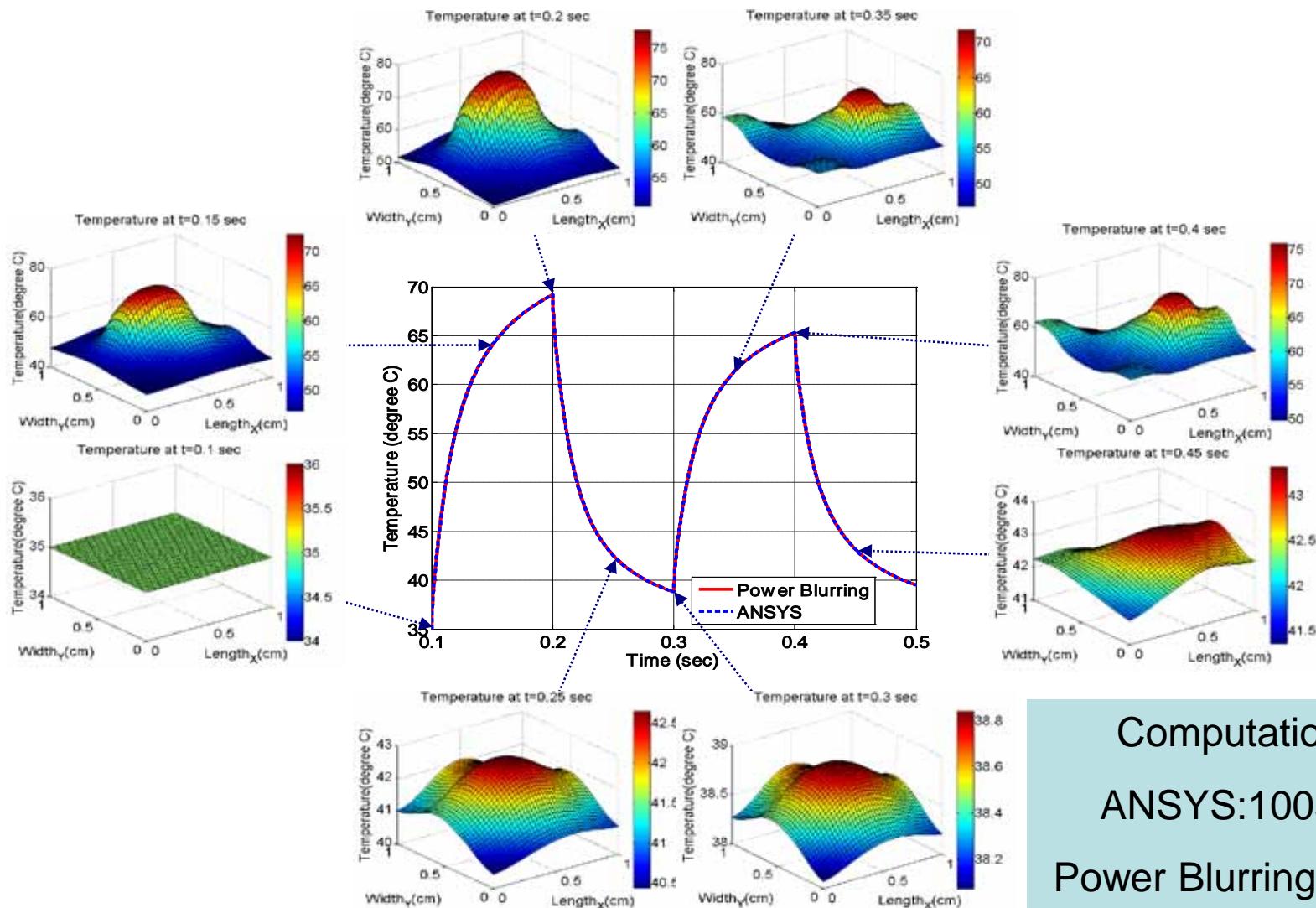


(Semitherm 2007  
-Xi Wang et al.)

# Transient Temperature Change in IC

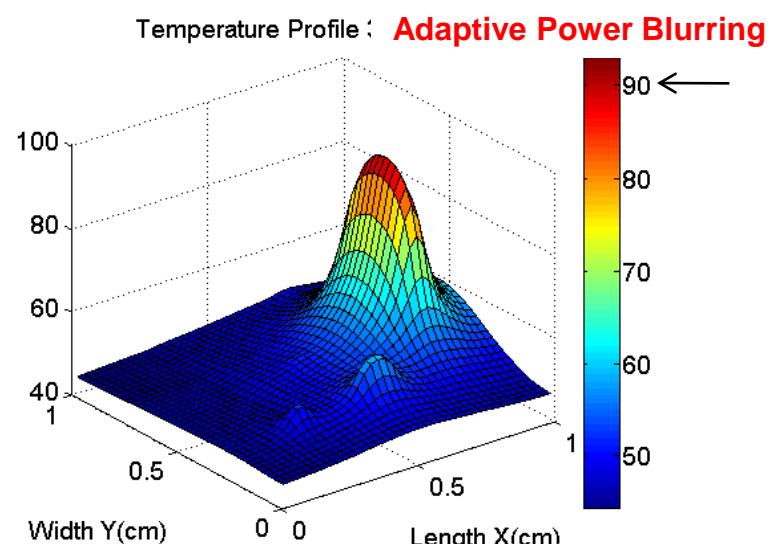
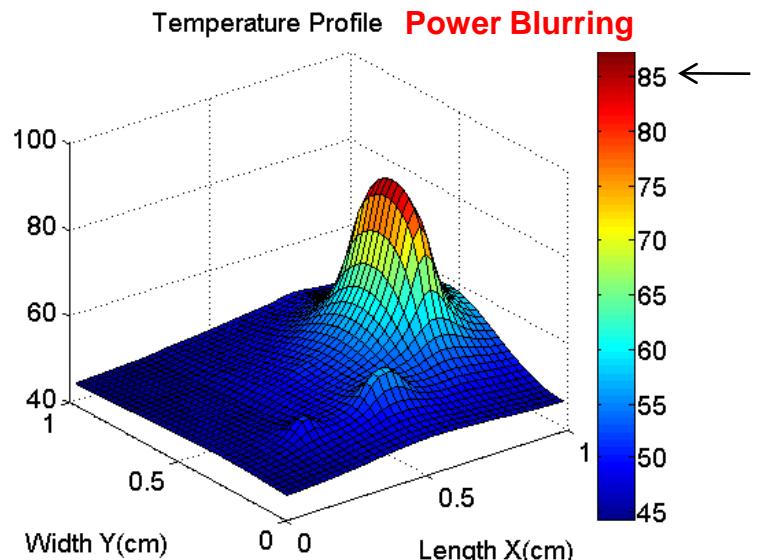
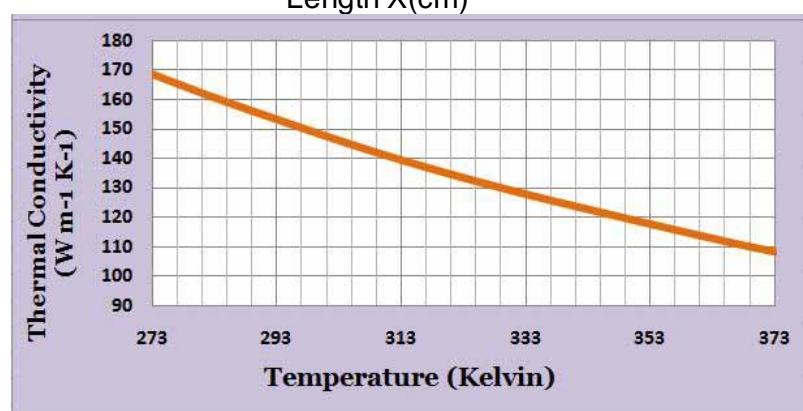
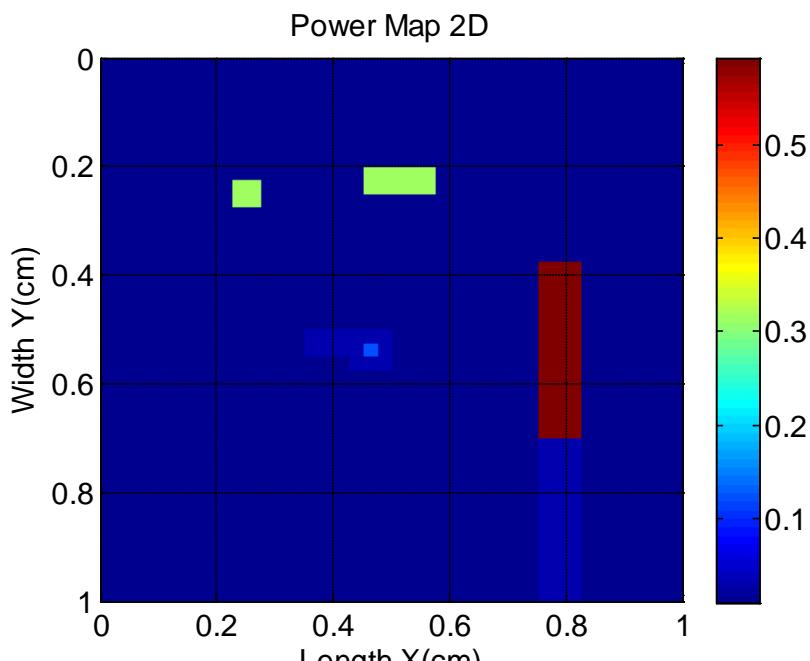


# Transient temperature at the chip center



Computation Time  
ANSYS: 10056 (sec)  
Power Blurring: 100 (sec)

# ADAPTIVE POWER BLURRING

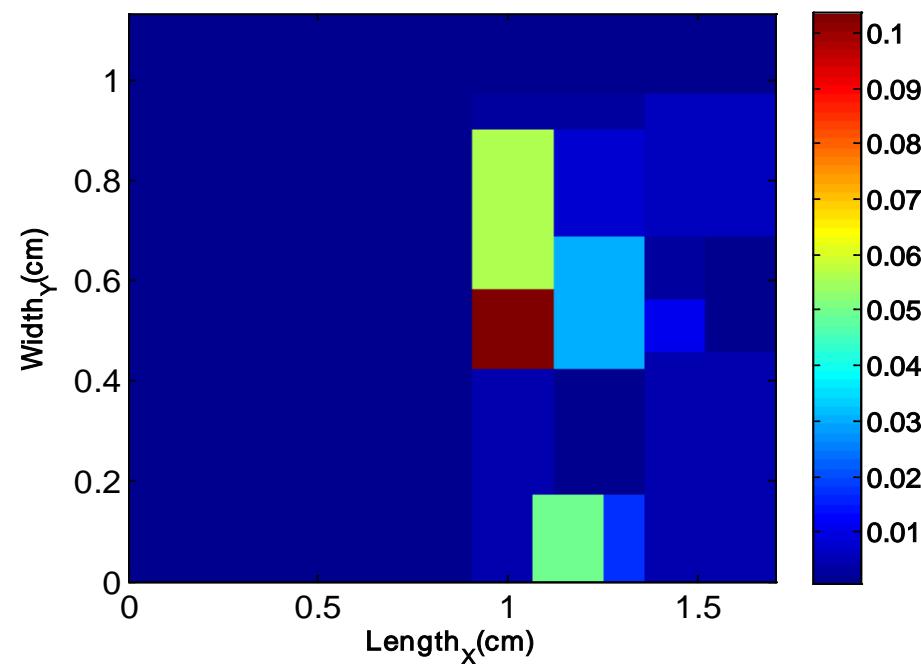


A. Ziabari et al, IMAPS, 2010.

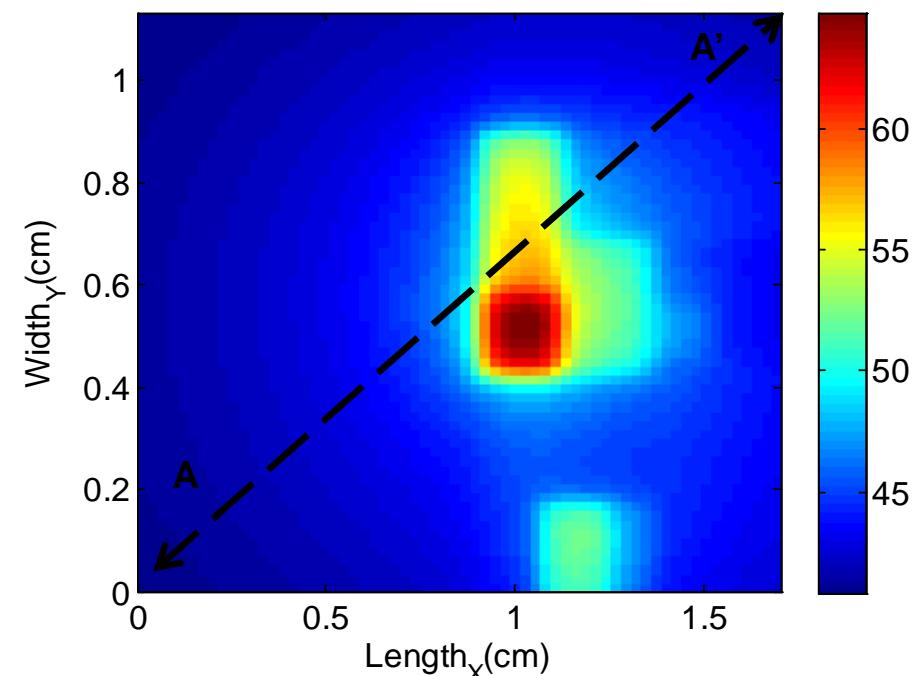
# Architecture level thermal simulations



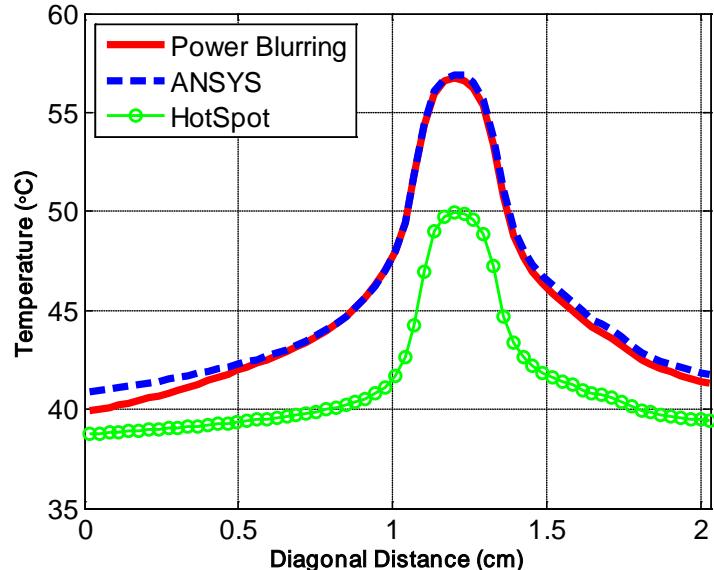
Power Distribution (Watt)



Temperature Distribution °C (ANSYS)

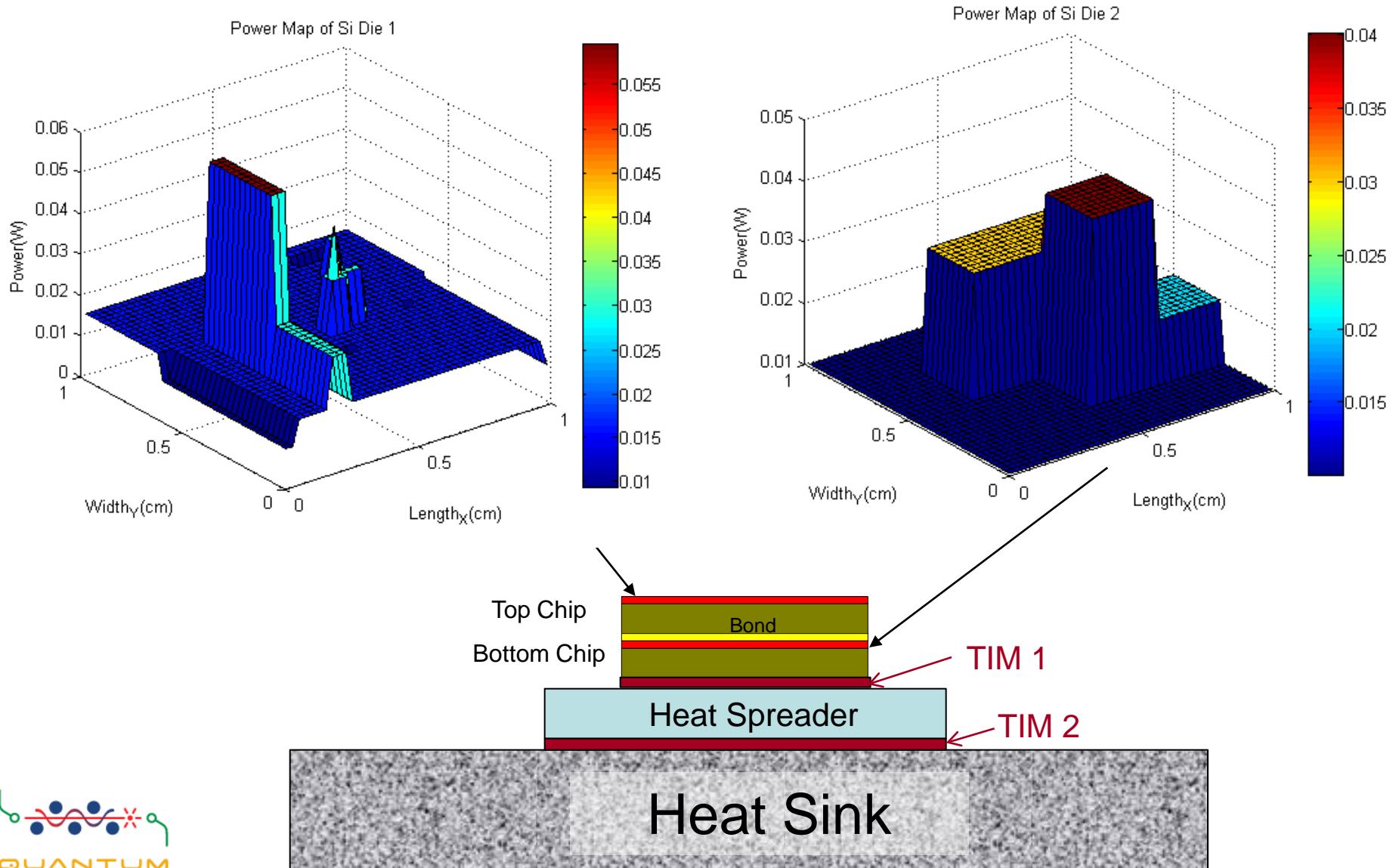


Path along A-A'

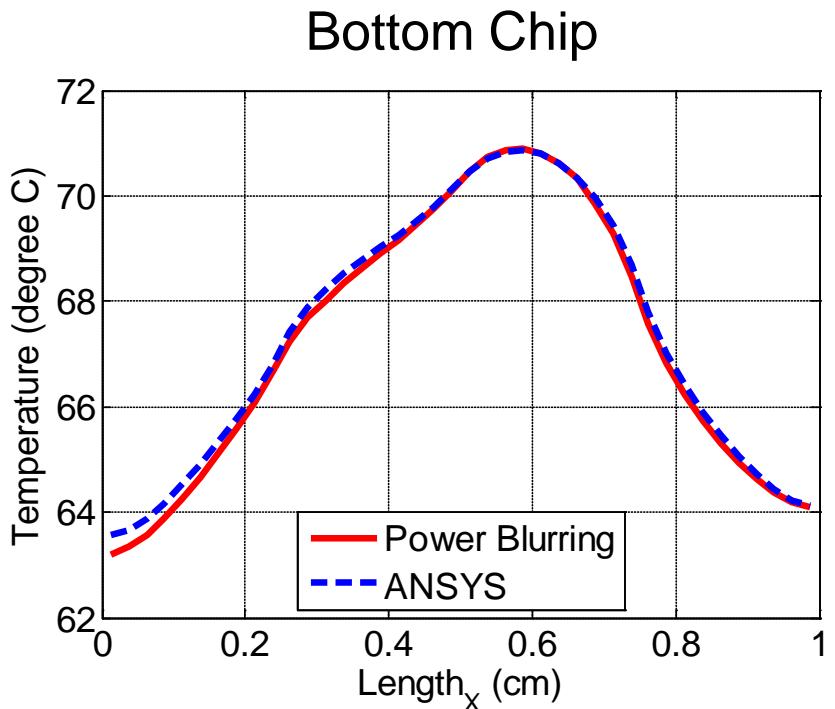
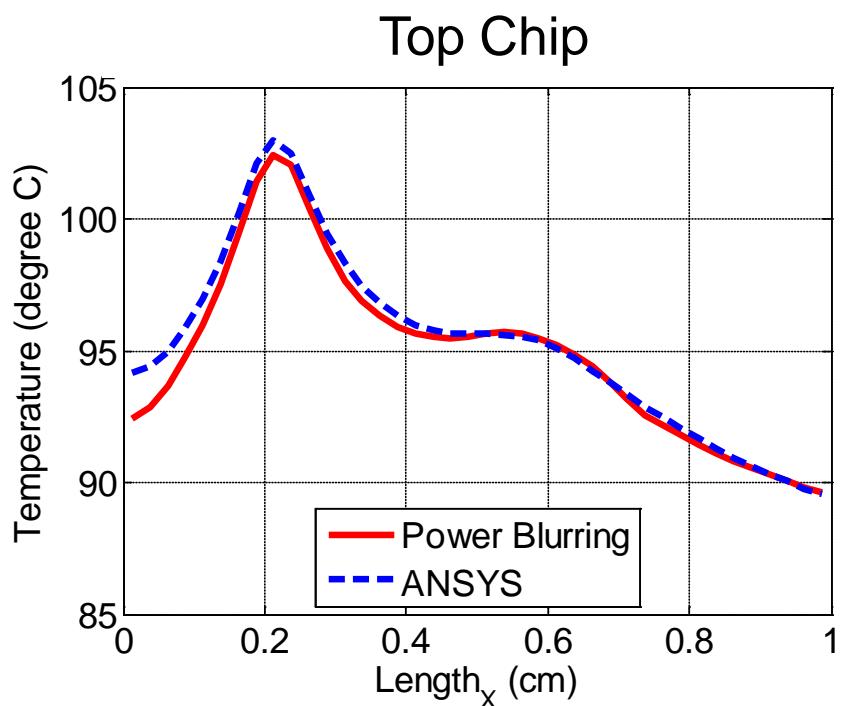


	<b>ANSYS</b>	<b>HotSpot</b>	<b>PB</b>
<b>Computation Time</b>	<b>56 s</b>	<b>0.11 s</b>	<b>0.041 s</b>
<b>Relative error at hottest spot</b>	-	<b>29%</b>	<b>0.3%</b>
<b>Absolute temperature error</b>	-	<b>2-9 °C</b>	<b>&lt;1 °C</b>

# 3D Chip Thermal Simulation



# Cross-section temperature profiles



Je-Hyoung Park, Ali Shakouri, and Sung-Mo Kang, “Fast Thermal Analysis of Vertically Integrated Circuits (3-D ICs) Using Power Blurring Method,” *Proceedings of the InterPACK Conference*, San Francisco, July 19-23, 2009.

# VISIT OUR WEB SITE



<http://quantum.soe.ucsc.edu/>

## Thermal Characterization Lab at NASA Ames Research Center

300 sq feet space for optical/thermal characterization system  
Resolution: 6mK temperature, 500 nm spatial, DC/Transient - 100ns

## Santa Cruz Campus

Exclusive research collaboration  
Sharing and transferring our techniques and tools via industrial affiliate program

### Major Equipment

High Temperature Cryostat System (4-1000K)  
Raman and Luminescence Spectroscopy System  
Thermal Imaging Camera  
Femto/Picosecond Laser  
Atomic Force Microscope  
Mid/Near-infrared Thermal Imaging (InSb, InGaAs cameras)  
OLYMPUS Fluoview FV1000-Confocal Microscope



# Summary

- Metal / semiconductor nanocomposites can improve thermoelectric energy conversion
  - Mid/long wavelength phonon scattering, Hot electron energy filtering
- Micro Refrigerators on a Chip (need  $ZT \sim 0.5$  on chip to cool  $1\text{mW/cm}^2$  hot spots by  $10-15^\circ\text{C}$ )
- Fast transient thermal imaging (~200nm, 0.2C, 800ps)
- Thermal characterization of high power transistors, ESD devices, solar cells, LEDs and copper vias
- Fast thermal simulation of packaged IC chips (adaptive power blurring) – $T$ -dependent material properties

A. Shakouri and M. Zeberjadi, "Chapter 9: **Nanoengineered Materials for Thermoelectric Energy Conversion**," in: *Thermal Nanosystems and Nanomaterials*, ed. by S. Volz, Springer, pp. 225-299 (2009)

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